

SPECIFICATION

MULTILAYER PRINTED WIRING BOARD AND ITS PRODUCTION PROCESS, RESIN COMPOSITION FOR FILLING THROUGH-HOLE

Technical Field

This invention relates to a multilayer printed wiring board used as a package board for mounting an IC chip or the like and a process of producing the same, and more particularly to a multilayer printed wiring board capable of providing a high density wiring easily and of preventing the formation of cracks or the like in through-holes or in the neighborhood thereof when heat cycle occurs, for example.

This invention also relates to a resist composition for filling through-hole of a multilayer printed wiring board, which is used for ensuring satisfactory electric connections between viaholes and through-holes even at high temperature and high humidity conditions or under such conditions as to cause heat cycle.

Background Art

In general, through-holes are formed for electrically connecting the front surface to the back surface of a core substrate (hereinafter simply referred to as "substrate") of a both-sided multilayer printed wiring board. These through-holes are, however, considered as dead spaces in designing of a circuit, and hence become one of the factors which prevent wiring from densifying.

For reducing such dead spaces, there have been disclosed, for example, following technologies;

① Japanese Unexamined Patent Publication No. 9-8424 discloses a technique of filling through-holes with a resin and roughening the resin on its surface and forming a mount

pad on the roughened surface.

② Japanese Unexamined Patent Publication No. 2-196494 discloses a technique of filling through-holes with a conductive paste, and dissolving and removing an electrolytic plated film covering through-holes to form landless through-holes.

③ Japanese Unexamined Patent Publication No. 1-143292 discloses a technique of filling through-holes with a conductive paste and subjecting the resultant substrate to a copper plating to form a plated film covering the paste.

④ Japanese Unexamined Patent Publication No. 4-92496 discloses a technique of forming, for example, a copper plated film onto all over the surface of a substrate inclusive of internal surfaces of through-holes by electroless plating, filling the inside of the through-holes with an electrically conductive material (conductive paste) and then covering the substrate with a copper plated film so as to encapsulate the electrically conductive material in the through-holes.

The conventional techniques mentioned above, however, have the following disadvantages.

① Such a both-sided multilayer printed wiring board as is described in Japanese Unexamined Patent Publication No. 9-8424 requires a roughening treatment of the surface of a resin in order to ensure adhesion between the resin filled in through-holes and the mount pad. In addition, since coefficients of thermal expansion between a resin and a metal are different, the conductor layer on the through-holes may peel or form cracks due to heat cycle.

② According to the technique described in Japanese

Unexamined Patent Publication No. 2-196494, when openings for viaholes are formed just above the through-holes of an interlaminar resin layer by laser beam, the conductive paste is exposed to the openings and thereby a resin ingredient in the conductive paste is also eroded.

③ In such a printed wiring board as is described in Japanese Unexamined Patent Publication No. 1-143292, the conductive paste is in direct contact with the internal surfaces of through-holes of a resin substrate so that metal ions are apt to disperse from the surfaces to the inside of the substrate when it takes up moisture. The dispersion (migration) of metal ions causes development of a short circuit between the conductor layer and the through-holes.

④ In such a printed wiring board as is described in Japanese Unexamined Patent Publication No. 4-92496, gaps or voids are tend to form because of a poor adhesion between the conductor layer and the electric conductive material in the through-holes. The formation of voids between the electric conductive material and a through-hole invites delamination of the conductor layer or generation of cracks on the through-hole in the use at high temperature and high humidity conditions due to air or water accumulated in the voids.

Incidentally, there may be some demands to connect a through-hole to a viahole formed on a substrate. In this case, connection is generally made by forming a pad called as land protruding on the periphery of the through-hole and connecting the through-hole to viahole through the interposition of the pad. The pad is, however, frequently obstructive because it is formed protruding on the outer

periphery of the through-hole and hence causes, for example, an increasing pitch between adjacent through-holes each other. This becomes an impediment to achieve a high density wiring or to narrower intervals between through-holes.

On the contrary, as examples conventional multilayer wiring boards having a high density wiring function, Japanese Unexamined Patent Publication No. 6-275959 discloses a multilayer printed wiring board obtained by filling through-holes with a filler, forming a conductor layer thereonto, and forming viaholes on the conductor layer, and Japanese Unexamined Patent Publication No. 5-243728 discloses a process of filling through-holes with a conductive paste and curing the paste, polishing a substrate on its surface and then forming a conductor layer covering the through-holes, and mounting a surface mount part on the conductor layer.

According to these conventional techniques, a surface mount part can be connected to through-holes so as to provide high density wiring or through-holes, but they have the following disadvantages.

⑤ The multilayer printed wiring board as practically exemplified in Japanese Unexamined Patent Publication No. 6-275959 is obtained by filling through-holes with a photosensitive resin as the filler. In such a wiring board, delamination between the filler and the conductor layer occurs when exposed to high temperature and high humidity conditions such as in Pressure Cooker Test, and a connection reliability between viaholes formed on the conductor layer and through-holes cannot be obtained.

⑥ The technique disclosed in Japanese Unexamined Patent

Publication No. 5-243728 is not a technique relating to a build-up multilayer printed wiring board and hence does not make the most of the high density wiring function inherent in the build-up method.

The present invention has been accomplished to solve the aforementioned problems inherent to the conventional techniques, and it is a main object of the invention to provide a multilayer printed wiring board which can easily ensure high density wiring and a production process thereof.

It is another object of the invention to provide a construction of a multilayer printed wiring board which is effective for preventing delamination between a filler for through-hole and a conductor layer, for inhibiting delamination and formation of cracks between a conductor circuit and an interlaminar insulating resin layer, for preventing metal ions in the filler from diffusing and for protecting the filler from erosion by a laser beam.

A further object of the invention is to provide high density through-hole intervals and wiring in a build-up multilayer printed wiring board without reducing an electric connection reliability between through-holes and viaholes at high temperature and high humidity conditions.

It is yet another object of the invention to provide a construction of a multilayer printed wiring board for ensuring a reliable electric connection between an internal layer circuit inside a substrate and build-up multilayer circuit layers on both surfaces of the substrate even when the substrate is multilayered.

A yet further object of the invention is to provide a construction of a resin composition used for filling

through-hole of the aforementioned multilayer printed wiring boards.

Disclosure of the Invention

The present invention provides a multilayer printed wiring board being composed of a substrate provided with through-holes, and a conductor circuit formed on the substrate through the interposition of an interlaminar insulating resin layer, the through-holes being filled with a filler, wherein the internal surfaces of the through-holes are roughened.

The invention also provides a multilayer printed wiring board being composed of a substrate provided with through-holes, and a conductor circuit formed on the substrate through the interposition of an interlaminar insulating resin layer, the through-holes being filled with a filler, wherein an exposed portion of the filler in the through-holes is covered with a through-hole-covering conductor layer.

In addition, the present invention provides a multilayer printed wiring board being composed of a substrate provided with through-holes, and a conductor circuit formed on the substrate through the interposition of an interlaminar insulating resin layer, the through-holes being filled with a filler, wherein an exposed portion of the filler in the through-holes is covered with a through-hole-covering conductor layer, and the through-hole-covering conductor layer is connected to a viahole formed just above the conductor layer.

The present invention provides, in another aspect, a process of producing a multilayer printed wiring board



comprising at least the following steps ① to ④:

- ① a step of forming a conductor layer and a through-hole on both surfaces of a substrate by electroless plating, or additionally by electroplating,
- ② a step of forming a roughened layer on the internal surface of the through-hole,
- ③ a step of filling the through-hole provided with the roughened layer on its internal surface with a filler, and
- ④ a step of forming an interlaminar insulating resin layer and then forming a conductor circuit by subjecting the substrate to an electroless plating, or additionally to an electroplating.

The invention provides, in yet another aspect, a process of producing a multilayer printed wiring board comprising at least the following steps ① to ④:

- ① a step of forming a conductor layer and a through-hole on both surfaces of a substrate by electroless plating, or additionally by electroplating,
- ② a step of filling the through-hole with a filler
- ③ a step of subjecting an exposed portion of the filler on the through-hole to an electroless plating, or additionally to an electroplating to form a through-hole-covering conductor layer, and
- ④ a step of forming an interlaminar insulating resin layer and then forming a conductor circuit by electroless plating, or additionally by electroplating.

The invention provides, in a yet further aspect, a process of producing a multilayer printed wiring board comprising at least the following steps ① to ⑥:

- ① a step of forming a conductor layer and a through-hole on



both surfaces of a substrate by electroless plating, or additionally by electroplating,

② a step of forming a roughened layer on the internal surface of the through-hole,

③ a step of filling the through-hole provided with the roughened layer on its internal surface with a filler,

④ a step of subjecting an exposed portion of the filler on the through-hole to an electroless plating, or additionally to an electroplating to form a through-hole-covering conductor layer,

⑤ a step of forming an interlaminar insulating resin layer, and

⑥ a step of forming a viahole and a conductor circuit in the interlaminar insulating resin layer located just above the through-hole, and connecting the viahole to the through-hole-covering conductor layer.

In addition and advantageously, the invention provides a resin composition for filling through-hole of a printed wiring board, which comprises a particulate substance, a resin and an ultrafine inorganic powder.

Brief Description of the Drawings

Fig. 1 is a cross section view illustrating an embodiment of the multilayer printed wiring board according to the present invention.

Fig. 2 (a)-(f) is a diagram illustrating a part of production steps of the multilayer printed wiring board according to the invention.

Fig. 3 (a)-(e) is a diagram illustrating a part of production steps of the multilayer printed wiring board according to the invention.



Fig. 4 (a)-(d) is a diagram illustrating a part of production steps of the multilayer printed wiring board according to the invention.

Fig. 5 (a)-(f) is a diagram illustrating a part of production steps of the multilayer printed wiring board according to the invention.

Fig. 6 (a)-(e) is a diagram illustrating a part of production steps of the multilayer printed wiring board according to the invention.

Fig. 7 (a)-(d) is a diagram illustrating a part of production steps of the multilayer printed wiring board according to the invention.

Fig. 8 (a) and (b) is an enlarged cross section view illustrating a part of the multilayer printed wiring board according to the invention.

Best Mode for Carrying Out the Invention

The multilayer printed wiring board according to the invention is characterized, as a first aspect, by forming a roughened layer on an internal surface conductor of the through-hole filled with a filler.

A second aspect of the printed wiring board according to the present invention is that a through-hole-covering conductor layer is formed for covering an exposed surface of the filler filling the through-hole.

The multilayer printed wiring board according to the invention is characterized, as a third aspect, by forming a viahole just above the through-hole-covering conductor layer which is formed just above the through-hole and by connecting the viahole to the conductor layer.

The present invention is characterized, as a fourth

feature, by proposing a resin composition for filling through-hole of the aforementioned multilayer printed wiring board.

In the first feature of the present invention, a roughened layer is formed on the internal surface of the through-hole in order to bring the filler into intimate contact with the through-hole via the roughened layer and to avoid the formation of voids. If a void is formed between the filler and the through-hole, a conductor layer formed just thereabove by electroplating becomes bumpy or air in the void expands by heat and causes cracks or delamination, whereas moisture accumulated in the void causes migration or cracks. The formation of a roughened layer can avoid such defects.

When the through-hole-covering conductor layer is formed on the filler filling the through-hole according to the second aspect of the invention, wiring can be installed just above the through-hole and a viahole can be connected directly thereto, as described below. In addition, when an opening for viahole is formed just above the through-hole in the interlaminar insulating resin layer by a laser beam, the through-hole-covering conductor layer plays a role of protecting a resin ingredient in the filler from erosion.

The viahole which is directly connected via the through-hole-covering conductor layer formed just above the through-hole according to the third aspect of the invention precludes the formation of a land (internal layer pad) for wiring around the through-hole as in conventional equivalents. In this case, the shape of the land of through-hole can remain a perfect circle. Accordingly, intervals

between through-holes formed in a substrate can be reduced so as to decrease dead spaces and increase the number of through-holes. In other words, this construction ensures intervals of adjacent through-holes to be as narrow as 700 μm or less.

Further, such a construction ensures lines of a back build-up wiring layer of the substrate to connect to a front build-up wiring layer through a multitude of through-holes. This means that wiring of the conductor circuit to the periphery of the substrate can be installed in both the front and back build-up layers. As described above, a plurality of wiring from plural bumps on the back surface are integrated and connected to bumps on the front surface in a multilayer printed wiring board. When through-holes are formed in high density, wiring can be integrated in front and back build-up wiring layers in the same condition so that the numbers of build-up wiring layers can be the same between the front and back surfaces and, in addition, can be reduced.

According to the present invention, the pitch between through-holes may be set to equal to or less than 700 μm in order to obtain the aforementioned operations and advantages. The pitch of equal to or less than 700 μm increases the number of through-holes and ensures connection from the front to the back build-up layers.

(1) Re: Roughened Layer;

A roughened layer is formed on the internal surfaces of the through-holes and/or on the surface of the through-hole-covering conductor layer which covers the filler exposed from the through-hole. In particular, the latter

roughened layer ensures a direct connection of a viahole to the through-hole-covering layer with a high reliability. Consequently, even when used at high temperature and high humidity conditions, high density wiring and through-holes in a build-up multilayer printed wiring board can easily be achieved without reducing electric connection reliability between the through-hole and viahole. In particular, when a roughened layer is additionally formed on the side face of the through-hole covering conductor layer, cracks in the interlaminar insulating resin layer starting from a boundary face between the side face of the through-hole-covering conductor layer and the interlaminar insulating resin layer can effectively be prevented from forming, whereas such cracks are generated due to a poor adherence therebetween.

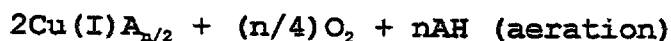
The thickness of the roughened layer formed on the internal surface of through-holes or on the surface of the conductor layer should preferably fall in the range from 0.1 to 10 μm . This is because a thicker roughened layer causes a short circuit between layers, whereas a thinner roughened layer decreases adhesion of the roughened layer with respect to an adherend.

These roughened layers may preferably be obtained by subjecting the conductor on the internal surface of through-holes or the surface of the through-hole-covering conductor layer to an oxidation (graphitization)-reduction treatment or a treatment with an aqueous mixture of an organic acid and a copper(II) complex, or a plating treatment with a needle-formed alloy of a copper-nickel-phosphorus.

In the process using the oxidation (graphitization)-reduction treatment, NaOH (10 g/l), NaClO₂ (40 g/l) and Na₃PO₄

(6 g/l) as an oxidation bath (graphitization bath), and NaOH g/l) and NaBH_4 (6 g/l) as a reduction bath are used.

In the treatment with an aqueous mixture of an organic acid-copper(II) complex, the solution acts as follows in the coexistence of oxygen such as in spraying or bubbling and dissolves a metal foil such as copper as a conductor circuit:



wherein A is a complexing agent (acting as a chelating agent) and n is a coordination number.

The copper(II) complex used in this treatment is preferably a copper(II) complex of an azole. The copper(II) complex of an azole acts as an oxidizing agent for oxidizing a metallic copper or the like. The preferred azole includes diazoles, triazoles and tetrazoles. Among them, imidazole, 2-methylimidazole, 2-ethylimidazole, 2-ethyl-4-methylimidazole, 2-phenylimidazole and 2-undecylimidazole are preferred.

The content of the copper(II) complex of an azole should preferably fall in the range from 1 to 15% by weight. Within this range, satisfactory solubility and stability can be obtained.

The organic acid is incorporated for dissolving a copper oxide.

As practical examples, at least one organic acid selected from formic acid, acetic acid, propionic acid, butyric acid, valeric acid, caproic acid, acrylic acid, crotonic acid, oxalic acid, malonic acid, succinic acid,

glutaric acid, maleic acid, benzoic acid, glycolic acid, lactic acid, malic acid and sulfamic acid is desirable.

The content of the organic acid may preferably fall in the range from 0.1 to 30% by weight. Within this range, solubility and dissolution stability of an oxidized copper can be maintained.

The produced copper(I) complex is dissolved by a function of an acid and bonded with oxygen to form a copper(II) complex and thereby to contribute oxidation of copper again.

Halogen ions such as fluorine ions, chlorine ions, bromine ions or the like may be added to the etchant comprising the organic acid-copper(II) complex for supplementing dissolution of copper or oxidation of an azole. The halogen ion can be supplied by adding hydrochloric acid, sodium chloride or the like to the solution.

The content of the halogen ion may preferably fall in the range from 0.01 to 20% by weight. Within this range, the formed roughened layer has a satisfactory adherence with respect to the interlaminar insulating resin layer.

The etchant comprising an organic acid-copper(II) complex may be prepared by dissolving a copper(II) complex of an azole and an organic acid (if necessary with halogen ion) in water.

The plating treatment with a needle-formed alloy of copper-nickel-phosphorus may preferably be conducted using a plating bath containing 1 to 40 g/l of copper sulfate, 0.1 to 6.0 g/l of nickel sulfate, 10 to 20 g/l of citric acid, 10 to 100 g/l of a phosphinate, 10 to 40 g/l of boric acid, and 0.01 to 10 g/l of a surfactant.

(2) Re: Filler;

The first filler (A) used in the invention should preferably be composed of metal particles, a thermosetting resin and a curing agent, or of metal particles and a thermoplastic resin, whereas a solvent can be added as necessary. When the surface of such a filler is polished, the metal particles contained in the filler are exposed so that the filler is integrated with a plating film formed thereon through the interposition of the exposed metal particles. Thus, delamination or peeling in a boundary face with respect to the conductor layer is prevented even when used at high temperature and high humidity conditions such as in Pressure Cooker Test (PCT). In addition, since the filler is charged in through-holes each provided with a metal film on its surface, migration of metal ions can be avoided. As the metal particles, there may be mentioned particles of copper, gold, silver, aluminium, nickel, titanium, chromium, tin/lead, palladium, platinum or others. The particle size of the metal particles may preferably fall in the range from 0.1 to 50 μm . When the particle size is less than 0.1 μm , surfaces of the metal particles are oxidized so as to reduce wettability of the filler with respect to the resin, whereas when it exceeds 50 μm , the print quality is deteriorated. The metal particles may preferably be incorporated in a ratio ranging from 30 to 90% by weight with respect to the total weight. When the ratio is less than 30% by weight, the adherence of the conductor layer covering an exposed filler from through-hole is deteriorated, whereas when it exceeds 90% by weight, the print quality is worsened.

Examples of the resin include epoxy resins, phenolic resins, polyimide resins, polytetrafluoroethylene (PTFE) and other fluororesins, bismaleimide-triazine (BT) resins, FEP, PFA, PPS, PEN, PES, nylon, aramid resins, PEEK, PEKK, PET and others.

The metal particles can be treated with a complexing agent or a modifier on their surfaces for improving their adherence with respect to the resin. For the thermosetting resin, any of imidazole-series, phenol-series or amine-series curing agents can be employed, and any of NMP (N-methylpyrrolidone), DMDG (diethylene glycol dimethyl ether), glycerin, water, 1-, 2- or 3-cyclohexanol, cyclohexanone, methyl cellosolve, methyl cellosolve acetate, methanol, ethanol, butanol, propanol, bisphenol A type epoxy and other solvents may be used.

The filler preferably has, as an optimum composition, a combination of a mixture of Cu powder and bisphenol F type solvent-free epoxy (manufactured by Yuka Shell Co., Ltd., trade name: E-807) in a weight ratio of 6:4 to 9:1 and a curing agent, or a combination of Cu powder, PPS and NMP in a weight ratio of 8:2:3.

As a second filler (B) used in the invention, there may be mentioned following ones. To be more specific, such a filler (B) should be distinguished from the aforementioned filler (B), and it is essentially characterized by comprising a particulate substance, a resin and an ultrafine inorganic powder.

The aforementioned resin composition for filling through-hole comprises an inorganic ultrafine powder having an average particle size preferably ranging from 1 to 1,000

nm (more preferably from 2 to 100 nm), and when it is charged in the through-hole, a meshwork formed as a function of an intermolecular force of the ultrafine inorganic powder traps the particulate substance so as to prevent isolation and precipitation of the particulate substance. As a result, the particulate substance can be engaged into the through-hole-covering conductor layer above the filler as an anchor, and in addition, crevices for anchoring can be formed by dissolving and removing the particulate substance to contribute to integration of the filler and the through-hole-covering conductor layer effectively. In particular, when the particulate substance is a metal particle, the metal particle is protruded from the surface of the filler so that the protruded metal particle and the through-hole-covering conductor layer covering the same are integrated to enhance the adherence therebetween.

Accordingly, delamination between the filler and the through-hole conductor layer can be prevented, and hence delamination between the filler and the conductor layer covering the filler can be prevented even at high temperature and high humidity conditions.

As the particulate substance, at least one member selected from metal particles, inorganic particles and resin particles is preferred. As the metal particles, those used in the filler (A) may be employed. The inorganic particles include particles of silica, alumina, mullite, silicon carbide and the like. To the surfaces of the organic particles, a surface-modifier such as a silane coupling agent can be added. As the resin particles, at least one member selected from epoxy resins, benzoguanamine resins and

amino resins is advantageously employed. These resins have satisfactory adherence with respect to the constitutive resin of the filler.

The particulate substance preferably has an average particle size ranging from 0.1 to 30 μm . Such an average particle size enhances adherence with respect to the through-hole-covering conductor layer covering the filler. The content of the particle substance may preferably fall in the range from 30 to 90% by weight based upon the total solid contents of the resin composition. Within this range, satisfactory adherence and print quality can be obtained simultaneously.

The constitutive resin (which should be distinguished from the aforementioned resin particle) of the resin composition for filling through-hole includes thermosetting resins and thermoplastic resins.

Preferred example of the thermosetting resin includes at least one member selected from epoxy resins, polyimide resins and phenolic resins.

As the thermoplastic resin, use may preferably made of at least one member selected from polytetrafluoroethylene (PTFE), tetrafluoroethylene-hexafluoropropylene copolymers (FEP), tetrafluoroethylene-perfluoroalcoxy copolymers (PFA) and other fluororesins, polyethylene terephthalates (PET), polysulfones (PSF), polyphenylene sulfides (PPS), thermoplastic polyphenylene ethers (PPE), polyether sulfones (PES), polyether imides (PEI), polyphenylene sulfones (PPES), polyethylene naphthalates (PEN), polyether ether ketones (PEEK), and polyolefin resins.

In particular, at least one member selected from

bisphenol type epoxy resins and novolac type epoxy resins can advantageously be used as the resin for filling through-hole. The viscosity of a bisphenol type epoxy resin can be regulated by selecting from A-type resins, F-type resins or others suitably without the use of a diluent solvent. A novolac type epoxy resin has a high strength, excellent heat resistance and chemical resistance and is not disintegrated even in a strongly basic solution such as a plating solution and not degraded by heat.

As the bisphenol type epoxy resin, use is preferably made of at least one member selected from bisphenol A type epoxy resins and bisphenol F type epoxy resins. Among them, bisphenol F type epoxy resins can advantageously be employed as they can be used at a low viscosity without any solvent. At least one member selected from phenol novolac type epoxy resins and cresol novolac type epoxy resins may preferably be employed as the novolac type epoxy resin.

When a combination of a novolac type epoxy resin and a bisphenol type epoxy resin is used, the composition ratio thereof should preferably fall in the range from 1/1 to 1/100 by weight. Within this range, excessive increase of the viscosity can be prevented.

The preferred curing agent used in the resin composition includes imidazole-series curing agents, acid anhydride-series curing agents and amine-series curing agents, since these curing agents exhibit a small shrinkage in curing. By preventing such shrinkage in curing, integration between the filler and the conductor layer covering the same can be enhanced and the adherence can be improved.

The resin composition may be diluted with a solvent as necessary. As the solvent, there may be mentioned NMP (N-methylpyrrolidone), DMDG (diethylene glycol dimethyl ether), glycerin, water, 1-, 2- or 3-cyclohexanol, cyclohexanone, methyl cellosolve, methyl cellosolve acetate, methanol, ethanol, butanol, propanol and the like.

Preferable ultrafine inorganic particle (which should be distinguished from the aforementioned inorganic particle) constituting the resin composition for filling through-hole includes silica, alumina, silicon carbide and mullite, among which silica is most desirable.

The ultrafine inorganic particle should have an average particle size ranging from 1 to 1,000 nm and more preferably from 2 to 100 nm. Within this range, the particle size is fine and thus repletion of through-holes is not deteriorated, and meshwork bonds, which are estimated as hydrogen bonds, can be formed so as to trap the particulate substance.

The content of the ultrafine inorganic particle should preferably fall in the range from 0.1 to 5% by weight relative to the total solid contents in the resin composition. This is because precipitation of the metal particle can be prevented without deteriorating repletion within this range.

The filler being composed of the resin composition as mentioned above should be a nonconducting filler having a specific resistance of equal to or more than $10^6 \Omega\cdot\text{cm}$ and more preferably equal to or more than $10^8 \Omega\cdot\text{cm}$. When the filler is electroconductive, cuttings of the filler is formed in polishing of the resin composition after curing,

and they adhere between the conductor circuit so as to cause a short circuit.

In addition, to impart electric conductivity to such a resin composition, the composition should be cured and shrunk. If such a shrinkage by curing is excessive, delamination between the filler and the through-hole-covering conductor layer covering the filler occurs.

(3) Re: Interlaminar insulating resin layer;

The interlaminar insulating resin layer according to the invention can be composed of an lower layer comprising a resin having excellent insulation properties and an upper layer comprising a resin having a satisfactory adherence, using any of thermosetting resins, thermoplastic resins or complexes of a thermosetting resin and a thermoplastic resin.

As the thermosetting resin, epoxy resins, polyimide resins, phenolic resins, thermosettable polyphenylene ethers (PPE) may be employed.

Examples of the thermoplastic resin include polytetrafluoroethylene (PTFE) and other fluororesins, polyethylene terephthalates (PET), polysulfones (PSF), polyphenylene sulfides (PPS), thermoplastic polyphenylene ethers (PPE), polyether sulfones (PES), polyether imides (PEI), polyphenylene sulfones (PPES), tetrafluoroethylene-hexafluoropropylene copolymers (FEP), tetrafluoroethylene-perfluoroalkoxy copolymers (PFA), polyethylene naphthalates (PEN), polyether ether ketones (PEEK) and polyolefin resins. The complex of a thermosetting resin and a thermoplastic resin includes an epoxy resin-PES, an epoxy resin-PSF, an epoxy resin-PPS, an epoxy resin-PPES and the like.

In the present invention, a glass cloth-impregnated

resin complex can be used as the interlaminar insulating resin layer. The glass cloth-impregnated resin complex includes a glass cloth-impregnated epoxy, a glass cloth-impregnated bismaleimide-triazine, a glass cloth-impregnated PTFE, a glass cloth-impregnated PPE, a glass cloth-impregnated polyimide and the like.

An adhesive for electroless plating can also be used as the interlaminar insulating resin layer in the present invention.

As the adhesive for electroless plating, an adhesive formed by dispersing cured heat-resistant particles soluble in an acid or an oxidizing agent into an uncured heat-resistant resin hardly soluble in an acid or an oxidizing agent through curing treatment is most desirable. The heat-resistant resin particles are dissolved and removed by a treatment with an acid or an oxidizing agent so as to form a roughened layer composed of reverse- Ω -formed anchors on its surface.

As the cured heat-resistant resin particles in the adhesive for electroless plating, particularly preferred is at least one member selected from ① heat-resistant resin particles having an average particle size of equal to or less than 10 μm , ② agglomerate particles obtained by aggregating heat-resistant resin powder having an average particle size of equal to or less than 2 μm , ③ a mixture of heat-resistant resin powder having an average particle size ranging from 2 to 10 μm and heat-resistant resin powder having an average particle size of equal to or less than 2 μm , ④ quasi-particles obtained by adhering at least one of heat-resistant resin powder or inorganic powder each having

an average particle size of equal to or less than 2 μm to surfaces of heat-resistant resin powder having an average particle size ranging from 2 to 10 μm , ⑤ a mixture of heat-resistant resin powder having an average particle size ranging from 0.1 to 0.8 μm and heat-resistant resin powder having an average particle size more than 0.8 μm and less than 2 μm , and ⑥ heat-resistant resin powder having an average particle size ranging from 0.1 to 1.0 μm . The use of any of these particles provides more complicated anchors.

As the heat-resistant resin used in the adhesive for electroless plating, the aforementioned thermosetting resins, thermoplastic resins and complexes of a thermosetting resin and a thermoplastic resin may be employed.

In the present invention, the conductor circuit (inclusive of the through-hole-covering conductor layer) formed on the substrate and the conductor circuit formed on the interlaminar insulating resin layer can be connected to each other through a viahole. The viahole may be filled with a plated film or a filler.

(4) Re: Production process of multilayer printed wiring board;

A process of producing the multilayer printed wiring board through a semi-additive process will be described below, whereas a full-additive process, a multilamination process and a pin lamination process can also be employed in the production process of the multilayer printed wiring board according to the invention.

(A) Formation of through-hole

①. Initially, a substrate is drilled to form holes, and the surfaces of the holes and a copper foil are subjected to an

electroless plating to form through-holes.

a. As the substrate, glass-epoxy substrates, polyimide substrates, bismaleimide-triazine resin substrates, fluororesin substrates and other resin substrates, copper-clad laminates of these resin substrates, ceramic substrates, metal substrates and the like can be used. In consideration of the permittivity, in particular, a both-sided copper-clad fluororesin substrate is advantageously employed. This substrate is obtained by thermo-compression bonding of a copper foil having a one-sided roughened layer to a fluororesin substrate such as polytetrafluoroethylene.

b. A multilayer core substrate can also be used as the substrate. The multilayer core substrate can be obtained by laminating a conductor layer and a prepreg in alternating order. By way of illustration, the core substrate is obtained by laminating a prepreg and a copper foil or a circuit board in alternating order, and heating and pressing the laminate to integrate, whereas the prepreg is prepared by impregnating a cloth or nonwoven fabric composed of glass fibers or aramid fibers with an epoxy resin, a polyimide resin, a bismaleimide-triazine resin, a fluororesin (such as polytetrafluoroethylene) or the like to form B-stage resin. As the circuit substrate, a substrate provided with a copper pattern obtained by forming an etching resist on both surfaces of a both-sided copper-clad laminate and subjecting it to etching can be employed.

c. As the electroless plating, a copper plating is preferred. When the substrate is poor in wettability of plating such as a fluororesin substrate, its surface should be modified by, for example, a treatment with a pretreatment agent composed

of an organic metallic sodium (manufactured by Junkosha Co., Ltd., trade name: Tetraetch), or plasma treatment.

②. Next, an electroplating is conducted for plating up. A copper plating is desirable as the electroplating.

When the roughened layer is formed by electroless plating, an aqueous plating solution containing 2.2×10^{-2} to 4.1×10^{-2} mol/l of copper ions, 2.2×10^{-3} to 4.1×10^{-3} mol/l of nickel ions and 0.20 to 0.25 mol/l of phosphinic acid ions is preferably employed. Within this composition, the crystal structure of a deposited film is in needle-form so as to exhibit a satisfactory anchoring effect.

A complexing agent and/or a additive can be added to the electroless plating aqueous solution in addition to the above compounds. Further, a surfactant may also be added to the solution in a concentration ranging from 0.01 to 10 g/l. Preferred surfactant includes, for example, acetylene-containing polyoxyethylene surfactants such as Surfinol 440, 465 and 485 manufactured by Nisshin Kagaku Kogyo Co., Ltd.

In other words, when the roughened layer is formed by electroless plating, an aqueous plating solution containing 1 to 40 g/l of copper sulfate, 0.1 to 6.0 g/l of nickel sulfate, 10 to 20 g/l of citric acid, 10 to 100 g/l of a phosphinate, 10 to 40 g/l of boric acid, and 0.01 to 10 g/l of a surfactant is advantageously used.

③. Further, a roughened layer is formed by roughing the internal surfaces of through-holes and the surface of the electrolytic plated film. The roughened layers may be obtained by a graphitization (oxidation)-reduction treatment, by spray-treatment with an aqueous mixture of an organic acid and a copper(II) complex, or by plating with a needle-

formed alloy of copper-nickel-phosphorus.

When the roughened layers are formed by an oxidation-reduction treatment, an oxidation bath containing NaOH (20 g/l), NaClO₂ (g/l) and Na₃PO₄ (15.0 g/l) and a reduction bath containing NaOH (2.7 g/l) and NaBH₄ 1.0 g/l) are preferably employed.

When the roughened layers are formed through etching with an aqueous solution of an organic acid and a copper(II) complex, the surface of copper is roughened as a function of oxidizing properties of divalent copper in the solution. A typical example of the solution includes CZ8100 solution manufactured by MEC Co., Ltd.

The roughened layer may be covered with a layer of a metal or noble metal having an ionization tendency of more than copper but less than titanium. Such a metal or noble metal layer covering the roughened layer can prevent the dissolution of the conductor circuit due to a local electrode reaction created in the roughening of the interlaminar insulating resin layer. The thickness of this layer is preferably from 0.01 to 2 μm .

As the metal, preferred is at least one metal selected from titanium, aluminium, zinc, iron, indium, thallium, cobalt, nickel, tin, lead and bismuth. The noble metal includes, for instance, gold, silver, platinum and palladium. Among them, tin is desirable, because it can form a thin layer through electroless substitution plating and can advantageously be followed to the roughened layer. When tin is employed, a solution of tin borofluoride-thiourea or tin chloride-thiourea is used. In this case, Sn layer having a thickness ranging from 0.01 to 2 μm is formed through Cu-Sn

substitution reaction. When a noble metal is used, sputtering method, vaporization method or the like is employed.

(2) Filling of filler

①. The through-holes formed in the step (1) are filled with a filler. To be more specific, the filler is charged into the through-holes by applying it, through printing process, onto the substrate on which a mask having openings according to the through-hole portions is placed, and then dried and cured.

According to the invention, a conductive paste can be employed instead of the filler. The conductive paste is composed of metal powder and a resin, whereas a solvent can be added thereto as necessary. As the metal powder, powder of Cu, Au, Ag, Al, Ni, Pd, Pt, Ti, Cr, Sn/Pb or the like may be used. The metal powder should preferably have a particle size ranging from 0.1 to 30 μm . The resin includes, for instance, epoxy resins, phenolic resins, polyimide resins, polytetrafluoroethylene (PTFE) and other fluororesins, bismaleimide-triazine (BT) resins, FEP, PFA, PPS, PEN, PES, nylon, aramid resins, PEEK, PEKK and PET. As the solvent, any of NMP (N-methylpyrrolidone), DMDG (diethylene glycol dimethyl ether), glycerin, water, 1-, 2- or 3-cyclohexanol, cyclohexanone, methyl cellosolve, methyl cellosolve acetate, methanol, ethanol, butanol, propanol, bisphenol A type epoxy and other solvents can be used.

In order to improve adherence between the metal powder and the resin, a modifier for metal surface such as a silane coupling agent may be added to the filler. In addition, other additives such as defoaming agents inclusive of

acrylic defoaming agents and silicon defoaming agents, silica, alumina, talc and other inorganic fillers can also be added. To the surfaces of the metal particle, a silane coupling agent may be attached.

The filler is printed in the following condition, for example. That is, printing is conducted using a print masking plate of Tetlon mesh plate and a square squeegee of 45° in the condition of Cu paste viscosity: 120 Pa·s, squeegee rate: 13 mm/min, squeegee amount: 1 mm.

②. The filler protruded from the through-hole and the surface of the electrolytic plated film on the substrate are removed by polishing to smooth the surface of the substrate. The polishing may preferably be carried out through belt sander abrasion or buffing. A part of the metal particles are exposed to the surface by the polishing and hence adherence between the metal particles and the through-hole-covering conductor layer is enhanced.

(3) Formation of conductor layer

①. Catalyst nuclei are applied to the smoothed surface of the substrate in the step (2), and then the surface is subjected to an electroless plating and an electroplating to form an electroless plated film having a thickness ranging from 0.1 to 5 μm . Where necessary, the surface is further subjected to an electroplating to form an electrolytic plated film having a thickness ranging from 5 to 25 μm .

Next, a photosensitive dry film is laminated onto the surface of the plated film, a photomask film (preferably made of glass) imaged with a pattern is placed thereon, exposed to light and then developed with a developer to form an etching resist. A portion where resist is not formed is

then subjected to etching to form a conductor circuit portion and a through-hole-covering conductor layer portion which covers the filler.

As the preferred etchant, there may be mentioned an aqueous solution of sulfuric acid-hydrogen peroxide, an aqueous solution of a peroxosulfate such as ammonium peroxodisulfate, sodium peroxodisulfate and potassium peroxodisulfate, or an aqueous solution of iron(II) chloride or copper(II) chloride.

②. The etching resist is then peeled off to form an independent conductor circuit and through-hole-covering conductor layer, and then a roughened layer is formed onto the surfaces of the conductor circuit and the through-hole-covering conductor layer.

When the roughened layer is formed on the surfaces of the conductor circuit and the through-hole-covering conductor layer, the conductors are excellent in adherence with respect to the interlaminar insulating resin layer so that cracks starting from a boundary face between the side face of the conductor circuit and through-hole-covering conductor layer which covers the filler and the insulating resin layer can be prevented. On the other hand, the through-hole-covering conductor layer covering the filler can effectively contribute to improvement of adherence with respect to viaholes which are electrically connected thereto. The roughened layers may be formed according to any of the processes mentioned above, such as a graphitization (oxidation)-reduction treatment, a plating with a needle-formed alloy or an etching process.

After roughening, a resin is applied and charged

between the conductor circuits and then cured in order to reduce unevenness due to the conductor layer formed on surface of the substrate. The surface of the resin should preferably be polished and smoothed so that the conductor is exposed. As the resin used for cladding, a resin composed of a bisphenol A type epoxy resin, bisphenol F type epoxy resin or other bisphenol type epoxy resin, an imidazole curing agent and inorganic particles is desirable. Such a bisphenol type epoxy resin has a low viscosity and a satisfactory applicability. Among them, a bisphenol F type epoxy resin can be applied without solvent, and hence is advantageous as to prevent the formation of cracks or delamination caused by volatilization of a solvent in heating and curing.

It is preferable that a roughed layer is formed on surface of each of the conductors after polishing.

As the forming process of the conductor layer, the following steps can be employed.

To be more specific, a plating resist is formed onto the substrate after completion of the steps ① and ②, and a non-resist-formed portion is subjected to an electroplating so as to form a conductor circuit and a through-hole-covering conductor layer portion. A solder plated film is then formed on these conductors using a solder electroplating solution composed of tin borofluoride, lead borofluoride, hydroborofluoric acid and peptone. The plating resist is then removed, and the electroless plating film and copper foil located beneath the plating resist are removed by etching, and then the solder plating film is dissolved and removed with an aqueous solution of borofluoric acid to form a conductor layer.

(4) Formation of interlaminar insulating resin layer and conductor circuit

①. An interlaminar insulating resin layer is formed on the conductor layer on the substrate thus prepared.

As the interlaminar insulating resin layer is used any of thermosetting resins, thermoplastic resins or complexes of a thermosetting resin and a thermoplastic resin. The aforementioned adhesive for electroless plating can also be used as a material for the interlaminar insulating resin.

The interlaminar insulating resin layer is formed by applying an uncured solution of any of these resins with a roll coater or a curtain coater, or laminating a resin film through thermo-compression bonding. At this time, the interlaminar insulating resin layer formed on the conductor circuit of the substrate frequently has a state of causing unevenness due to the fact that the thickness of the interlaminar insulating resin layer on the conductor circuit pattern is thin and the thickness of the interlaminar insulating resin layer on the conductor circuit having a large area is thick. Accordingly, it is desirable that the surface of the interlaminar insulating resin layer is smoothed by pressing a metal plate or a metal roll onto the interlaminar insulating resin layer of the uneven state while heating.

②. Next, an opening is formed in the interlaminar insulating resin layer to ensure an electric connection with respect to a lower-layer conductor circuit covered by the interlaminar insulating resin layer.

The opening is formed by light exposure and development when the interlaminar insulating resin layer is

composed of a photosensitive resin, and by a laser beam irradiation when it is composed of a thermosetting resin or a thermoplastic resin. The laser beam includes a carbon dioxide gas laser, an ultraviolet ray laser, an excimer laser and the like. When the opening is formed by a laser beam irradiation, the substrate may be subjected to a desmearing treatment. The desmearing treatment can be conducted using an oxidizing agent composed of an aqueous solution of chromic acid, a permanganate or the like, or by a treatment with an oxygen plasma.

③. After forming the interlaminar insulating resin layer provided with the opening, its surface is roughened as necessary.

When the above-mentioned adhesive for electroless plating is used as the interlaminar insulating resin layer, the surface of the insulating layer is subjected to a roughening treatment by selectively removing only the heat-resistant resin particles existing in the surface of the insulating layer through dissolution or decomposition with an acid or an oxidizing agent. As the acid, there may be mentioned phosphoric acid, hydrochloric acid, sulfuric acid, or organic acids including formic acid, acetic acid and others. Particularly, the use of the organic acid is desirable, because it hardly corrodes the metal conductor layer exposed from the viahole in the roughening treatment.

As the oxidizing agent, it is desirable to use chromic acid, or a permanganate (potassium permanganate or the like).

When a thermosetting resin or a thermoplastic resin is employed as the insulating resin layer, a roughening treatment on the surface of the layer using an oxidizing

agent selected from aqueous solutions of chromic acid, permanganates and the like is also effective.

In case of a fluororesin (polytetrafluoroethylene or the like) which is not roughened by an oxidizing agent, the surface of the layer is roughened by, for example, a plasma treatment or a treatment with Tetraetch (a metallic naphthalene compound manufactured by Junkosha Co., Ltd.).

④. Catalyst nuclei for electroless plating are applied to the resin layer.

In general, palladium-tin colloid is used as the catalyst nuclei. The substrate is dipped in a solution of the colloid, dried and then heated to fix the catalyst nuclei on the surface of the resin. Alternatively, the catalyst nuclei can be formed by driving metal nuclei onto the surface of the resin through CVD, sputtering or plasma.

In this case, the metal nuclei are embedded on the surface of the resin, and plating is deposited with the metal nuclei as cores to form conductor circuits. Therefore, even when a resin which is hardly roughened or a resin having a poor adherence with respect to the conductor circuit such as a fluororesin (polytetrafluoroethylene or the like) is used, adherence can be ensured. As the metal nuclei, at least one metal selected from palladium, silver, gold, platinum, titanium, copper and nickel is preferred.

The amount of the metal nuclei should preferably be equal to or less than $20 \mu\text{g}/\text{cm}^2$. When it exceeds this range, removal of the metal nuclei is required.

⑤. An electroless plated film is formed on the full surface of the interlaminar insulating resin layer by subjecting the layer to an electroless plating. The electroless plated film

should preferably have a thickness ranging from 0.1 to 5 μm , and more preferably from 0.5 to 3 μm .

⑥. A plating resist is formed on the electroless plated film. The plating resist is formed by laminating a photosensitive resin film on the plated film and subjecting the resultant laminate to a light exposure and development, as mentioned above.

⑦. An electrolytic plated film is formed on the electroless plated film other than the portion on which the plating resist is formed to plate up the conductor circuit portion (inclusive of the viahole portion). As the electroplating, it is desirable to use an electrolytic copper plating, and the thickness thereof is favorably from 5 to 30 μm .

⑧. After removing the plating resist, the electroless plated film beneath the plating resist is removed by dissolving in an etchant to form independent conductor circuits (including viaholes).

As the etchant, an aqueous solution of a mixture of sulfuric acid and hydrogen peroxide, an aqueous solution of a persulfate such as ammonium persulfate, sodium persulfate and potassium persulfate, an aqueous solution of iron chloride, copper chloride or the like is advantageously used.

It is desirable that the viaholes are filled with an electrolytic plated metal to form so-called filled viaholes in order to ensure smoothness of the interlaminar insulating resin layer.

Preferred embodiments of the multilayer printed wiring board of the present invention will now be described with reference to the drawings.

Fig. 1 is a cross section view illustrating a

multilayer printed wiring board according to an embodiment of the invention, which has a construction composed of a substrate 100, and build-up wiring layers 101A, 101B respectively formed on the front and back surfaces of the substrate 100. Each of the build-up layers 101A, 101B is composed of an interlaminar insulating resin layer 104 provided with a viahole 102 and a conductor circuit 103, and an interlaminar insulating resin layer 204 provided with a viahole 202 and a conductor circuit 203.

A solder bump 105 is formed on the front surface for connecting to a bump of an IC chip (not shown), and a solder bump 106 is formed on the back surface for connecting to a bump of a mother board (not shown). In the multilayer printed wiring board, a conductor circuit starting from the solder bump 105 connecting to the IC chip is routed in the peripheral direction of the substrate, and connected to the solder bump 106 connecting to the mother board. The front build-up layer 101A and the back build-up layer 101B are connected to each other through through-holes 107 formed on the substrate 100.

To be more specific, the through-holes 107 are filled with a filler 108, and a through-hole-covering conductor layer 109 is so formed as to cover an exposed surface of the filler 108 from the through-holes 107. The upper-layer viahole 102 is connected to the conductor layer 109, and, the upper-layer viahole 202 is connected to the conductor circuit 103 connecting to the viahole 102. The solder bumps 105, 106 are formed on the viahole 202, or on the conductor circuit 203 connecting to the viahole 202.

In the multilayer printed wiring board according to

the invention, which has the aforementioned construction, the through-hole-covering conductor layer 109 located above the filler 108 in the through-holes 107 is formed round, and the viahole 102 is connected directly to the conductor layer 109. By connecting in the above manner, the areas just above the through-holes 107 can play a role as an internal layer pad and hence the formation of a dead space can be avoided. In addition, the wiring board does not require addition of an internal layer pad for connecting from the through-holes 107 to the viahole 102 as in conventional equivalents, the land shape of the through-hole 107 can be set to round. As a result, the number of through-holes can be increased by densifying the through-holes 107 formed in the substrate 30.

Thus, routing for dispersing the conductor circuits to the periphery of the substrate can be conducted on both the front and back build-up layers 101A, 101B. In a multilayer printed wiring board, a plurality of wiring from plural front bumps are connected to back bumps while being integrated, as described above. By forming the through-holes in a high density, wiring can be integrated at the same pace between the front and back build-up wiring layers 101A, 101B.

Accordingly, the numbers of the layers of the front and back build-up wiring layers 101A, 101B can be set to the same and can be reduced.

EXAMPLES

(Example 1)

(1) As a starting material, was employed a copper-clad laminate (manufactured by Matsushita Electric Works, Ltd., trade name: R4737) composed of a substrate 1 of a polytetrafluoroethylene resin (hereinafter briefly referred

to as trade name: Teflon) of 0.8 mm in thickness and a copper foil 2 of 18 μm in thickness laminated on the substrate 1, the surface adjacent to the copper foil 2 being roughened (see Fig. 2 (a)). Initially, the copper-clad laminate was drilled to form a hole and the internal surface of the hole was treated with a modifier (manufactured by Junkosha Co., Ltd., trade name: Tetraetch) composed of an organic metallic sodium to improve the wettability of the surface (see Fig. 2 (b)).

A palladium-tin colloid was then applied to substrate, and the substrate was immersed in an electroless plating solution having the following composition to form an electroless plated film of 2 μm in thickness all over the surface of the substrate.

[Electroless plating solution]

EDTA	150 g/l
Copper sulfate	20 g/l
HCHO	30 ml/l
NaOH	40 g/l
α, α' -Bipyridyl	80 mg/l
PEG	0.1 g/l

[Electroless plating condition]

at a liquid temperature of 70°C for 30 minutes

Further, the substrate was subjected to an electrolytic copper plating under the following conditions to form an electrolytic copper plated film having a thickness of 15 μm (see Fig. 2 (c)).

[Electrolytic plating solution]

Sulfuric acid	180 g/l
Copper sulfate	80 g/l

Additive (manufactured by Atotech Japan, trade name:
Capalacid GL) 1 ml/l

[Electrolytic plating condition]

Current density 1 A/dm²

Time 30 minutes

Temperature room temperature

(2) The substrate provided with conductors (inclusive of through-holes 3) composed of the electroless plated copper film and electrolytic plated copper film was washed with water and dried. The substrate was then subjected to an oxidation-reduction treatment using an oxidation bath (graphitization bath) containing NaOH (10 g/l), NaClO₂ (40 g/l) and Na₃PO₄ (6 g/l), and a reduction bath containing NaOH (10 g/l) and Na₄ or NaBH₄ (6 g/l) to form a roughed layer 4 all over the surfaces of the conductors inclusive of the through-holes 3 (see Fig. 2 (d)).

(3) Next, the through-holes 3 were filled with a filler 5 composed of copper particles having an average particle size of 10 μm, a bisphenol F type epoxy resin/an imidazole curing agent = 70/25/5 (by weight) through screen printing, and then dried and cured. The roughened layer 4 located above the conductors and the filler 5 protruded from the through-holes 3 were removed by belt sander abrasion using a #600 belt abrasive paper (manufactured by Sankyo Rikagaku Co., Ltd.), and the substrate was further subjected to buffing for removing scratches caused by the belt sander abrasion to smooth the surface of the substrate (see Fig. 2 (e)).

(4) A palladium catalyst (manufactured by Atotech) was applied to the surface of the substrate smoothed in the above step (3), and the substrate was then subjected to an

electroless copper plating according to a conventional method to form an electroless copper plated film 6 having a thickness of 0.6 μm (see Fig. 2 (f)).

(5) An electrolytic copper plated film 7 having a thickness of 15 μm was then formed on the substrate by an electrolytic copper plating under the following conditions to plate up portions to be conductor circuits and those to be through-hole-covering conductor layer covering the filler 5 charged in the through-holes 3.

[Electrolytic plating solution]

Sulfuric acid	180 g/l
Copper sulfate	80 g/l
Additive (manufactured by Atotech Japan, trade name: Capalacid GL)	1 ml/l

[Electrolytic plating condition]

Current density	1 A/dm ²
Time	30 minutes
Temperature	room temperature

(6) A commercially available photosensitive dry film was adhered to both surfaces of the substrate provided with portions to be the conductor circuits and the through-hole-covering conductor layer, and a mask was placed on the film. The resultant substrate was then exposed to a light at 110 mJ/cm², developed with a 0.8% sodium carbonate solution to form an etching resist 8 having a thickness of 15 μm (see Fig. 3 (a)).

(7) The plated film in the portion where the etching resist 8 was not formed was removed by dissolving the film through etching with a mixture of sulfuric acid and hydrogen peroxide, and the etching resist 8 was peeled off by a 5%

KOH solution to form an independent conductor circuits 9 and a through-hole-covering conductor layer 10 covering the filler 5 (see Fig. 3 (b)).

(8) A roughened layer 11 of a Cu-Ni-P alloy having a thickness of 2.5 μm was formed on the surfaces of the conductor circuits 9 and the through-hole-covering conductor layer 10 covering the filler 5, and a Sn layer having a thickness of 0.3 μm was formed on the surface of the roughened layer 11 (see Fig. 3 (c), the Sn layer is not shown).

These layers were formed in the following manner: The substrate was acidically degreased and soft-etched, followed by a treatment with a catalyst solution of palladium chloride and an organic acid to give a Pd catalyst. After activating the catalyst, the substrate was immersed in an electroless plating solution of pH of 9 containing 8 g/l of copper sulfate, 0.6 g/l of nickel sulfate, 15 g/l of citric acid, 29 g/l of sodium hypophosphite, 31 g/l of boric acid and 0.1 g/l of a surfactant to form a roughened layer 11 of a Cu-Ni-P alloy on the surfaces of the conductor circuits 9 and the through-hole-covering conductor layer 10 covering the filler 5. The substrate was then subjected to a Cu-Sn substitution reaction at a temperature of 50°C and pH of 1.2 using an aqueous solution containing 0.1 mol/l of tin borofluoride and 1.0 mol/l of thiourea to form a Sn layer of 0.3 μm in thickness on the surface of the roughened layer 11 (the Sn layer is not shown). (9) Teflon sheets (manufactured by Du Pont Company, trade name: Teflon[®] FEP) of 25 μm in thickness were laminated respectively to both surfaces of the substrate at a temperature of 200°C and a pressure of 20

kg/cm², and then annealed at a temperature of 290°C to form an interlaminar insulating resin layer 12 (see Fig. 3 (d)).

(10) An opening 13 for the formation of viahole having a diameter of 25 μm was formed in the insulating Teflon resin layer 12 by an ultraviolet ray laser of 10.6 μm in wavelength (see Fig. 3 (e)). Further, the surface of the insulating Teflon resin layer 12 was roughened by a plasma treatment. The plasma treatment was carried out at 500 W and a pressure of 500 mTorr for 10 minutes.

(11) A Pd nucleus was embedded into the surface of the insulating Teflon resin layer 12 by sputtering with the use of Pd as a target at an atmospheric pressure of 0.6 Pa, a temperature of 100°C and a power of 200 W for 1 minute. At this time, SV-4540 manufactured by Nihon Shinku Gijutstu K.K. was used as a device for sputtering.

The amount of the sputtered Pd was set to equal to or less than 20 μg/cm². The Pd amount was determined by immersing the substrate in a 6 N hydrochloric acid solution, measuring the total amount of eluted Pd and dividing the total Pd by the exposing area.

(12) The substrate after the treatment in the step (11) was subjected to the electroless plating in the step (1) to form an electroless plated film 14 of 0.7 μm in thickness on the surface of the insulating Teflon resin layer 12 (see Fig. 4 (a)).

(13) Commercially available photosensitive dry films were separately laminated on both surfaces of the substrate provided with the electroless plated film 14 in the step (12), and photomask films were placed thereon, and the substrate was exposed to a light at 100 mJ/cm² and developed

with a 0.8% sodium carbonate solution to form a plating resist 16 having a thickness of 15 μm (see Fig. 4 (b)).

(14) An electrolytic plated film 15 having a thickness of 15 μm was formed on the substrate by electroplating described in the step (1) to plate up the portions of the conductor circuit 9 and to fill the portion of the viahole 17 with a plating (see Fig. 4 (c)).

(15) Further, after peeling off the plating resist 16 with a 5% KOH solution, the electroless plated film 14 located beneath the plating resist 16 was removed by dissolving through etching with the use of a mixture of sulfuric acid and hydrogen peroxide to form conductor circuits 9' (including filled viaholes 17) of 16 μm in thickness composed of the electroless copper plated film 14 and the electrolytic copper plated film 15. Thus, a multilayer printed wiring board was manufactured (see Fig. 4 (d)).

(Example 2) Multilayer core substrate

(1) A both-sided copper-clad laminate 1' of 0.5 mm in thickness was prepared, and provided with an etching resist on both surfaces, and subjected to an etching treatment with an aqueous solution of sulfuric acid and hydrogen peroxide to obtain a substrate provided with conductor circuits. A glass-epoxy prepreg and a copper foil 2 were in turn laminated onto both surfaces of the substrate, pressed at a temperature ranging from 165 to 170°C and a pressure of 20 kg/cm^2 to give a multilayer core substrate 1' (see Fig. 5 (a)).

(2) The multilayer core substrate 1' was then drilled to form through holes having a diameter of 300 μm (see Fig. 5 (b)), applied with a palladium-tin colloid and then immersed

in an electroless plating solution having the same composition as in Example 1 to form an electroless plated film of 2 μm in thickness all over the substrate.

The substrate was then subjected to an electrolytic copper plating in the same condition as in Example 1 to form an electrolytic copper plated film 3 having a thickness of 15 μm (see Fig. 5 (c)).

(3) A roughened layer 4 was formed all over the surface of the conductor 3 inclusive of through-holes in the same manner as in Example 1 (see Fig. 5 (d)).

(4) A filler 5 (a nonconducting copper paste for filling, manufactured by Tatsuta Densen Co., Ltd., trade name: DD Paste) containing copper particles having an average particle size of 10 μm was charged into the through-hole 3, and the surface of the substrate was smoothed (see Fig. 5 (e)).

(5) An electroless copper plated film 6 was then formed on the surface of the substrate smoothed in the step (4) in a similar manner to Example 1 (see Fig. 5 (f)).

(6) An electrolytic copper plated film 7 of 15 μm in thickness was formed by subjecting the substrate to an electrolytic copper plating according to the conditions of the step (2) in a similar manner to Example 1 to form portions to be a conductor circuits 9 and a through-hole-covering conductor layer 10 (to be a round through-hole land).

(7) An etching resist 8 was formed on both surfaces of the substrate provided with portions to be the conductor circuits 9 and the conductor layer 10 in the same manner as in Example 1 (see Fig. 6 (a)).

(8) The plated film in the portion where the etching resist was not formed was peeled off in a similar manner to Example 1 to form independent conductor circuits 9 and a through-hole-covering conductor layer 10 covering the filler 5 (see Fig. 6 (b)).

(9) Subsequently, a roughened layer 11 was formed on the surfaces of the conductor circuit 9 and the through-hole-covering conductor layer 10 covering the filler 5 in the same manner as in Example 1.

(10) An adhesive A for electroless plating and an insulating agent B were prepared in the following manner.

A. Preparation of adhesive A for upper-layer electroless plating

①. To 35 parts by weight (solid content 80%) of a 25% acrylated product of a cresol novolac type epoxy resin (manufactured by Nippon Kayaku Co., Ltd., molecular weight: 2,500) were added 3.15 parts by weight of a photosensitive monomer (manufactured by Toa Gosei Co., Ltd., Aronix M315), 0.5 part by weight of a defoaming agent (manufactured by Sannopko, S-65) and 3.6 parts by weight of NMP, and the resultant mixture was admixed with stirring.

②. A mixture of 12 parts by weight of polyether sulfone (PES), 7.2 parts by weight of epoxy resin particles (manufactured by Sanyo Kasei Co., Ltd., Polymerpole) having an average particle size of 1.0 μm , 3.09 parts by weight of the epoxy resin particles having an average particle size of 0.5 μm was stirred. Subsequently, 30 parts by weight of NMP was added to the mixture and stirred and admixed by a bead mill.

③. A mixture of 2 parts by weight of an imidazole curing

agent (manufactured by Shikoku Kasei Co., Ltd., 2E4MZ-CN), 2 parts by weight of a photoinitiator (manufactured by Ciba Geigy, Irgacure I-907), 0.2 part by weight of a photosensitizer (manufactured by Nippon Kayaku Co., Ltd., DETX-S) and 1.5 parts by weight of NMP was admixed by stirring.

An adhesive composition A for upper-layer electroless plating was prepared by mixing the above mixtures ① to ③.

B. Preparation of insulating agent B for lower-layer electroless plating

①. To 35 parts by weight (solid content: 80%) of a 25% acrylated product of a cresol novolac type epoxy resin (manufactured by Nippon Kayaku Co., Ltd., molecular weight: 2,500) were added 4 parts by weight of a photosensitive monomer (manufactured by Toa Gosei Co., Ltd., Aronix M315), 0.5 part by weight of a defoaming agent (manufactured by Sannopko, S-65) and 3.6 parts by weight of NMP, and the resultant mixture was stirred.

②. After admixing 12 parts by weight of polyether sulfone (PES) and 14.49 parts by weight of an epoxy resin particles (manufactured by Sanyo Kasei Co., Ltd., Polymerpole) having an average particle size of 0.5 μm , 20 parts by weight of NMP was added to the mixture and the resultant mixture was mixed while stirring by a bead mill.

③. A mixture of 2 parts by weight of an imidazole curing agent (manufactured by Shikoku Kasei Co., Ltd., 2E4MZ-CN), 2 parts by weight of a photoinitiator (manufactured by Ciba Geigy, Irgacure I-907), 0.2 part by weight of a photosensitizer (manufactured by Nippon Kayaku Co., Ltd., DETX-S) and 1.5 parts by weight of NMP was admixed while

stirring.

An insulating agent B for lower-layer electroless plating was prepared by admixing the above mixtures ① to ③.

(11) The insulating agent B for electroless plating (viscosity: 1.5 Pa·s) prepared in the step (10) was applied onto both surfaces of the substrate with a roll coater and allowed to stand in a horizontal position for 20 minutes, and then dried at a temperature of 60°C for 30 minutes. Subsequently, the adhesive A for electroless plating (viscosity: 1.0 Pa·s) was applied to the substrate by a roll coater, allowed to stand in a horizontal position for 20 minutes, and then dried at a temperature of 60°C for 30 minutes to form an adhesive layer 12 (two-layer structure) having a thickness of 40 μm (see Fig. 6 (d), the two-layer structure of the adhesive layer, however, is omitted in the view).

(12) A photomask film depicted with a full circle (black circle) of 85 μm in diameter was attached to both surfaces of the adhesive layers 12 formed on both surfaces of the substrate and exposed to a light irradiation at 500 mJ/cm^2 by an ultra-high pressure mercury lamp. The exposed substrate was developed by spraying a DMDG (diethylene glycol dimethyl ether) solution to form openings for viahole of 85 μm in diameter on the adhesive layer. The substrate was further exposed to a light irradiation at 3,000 mJ/cm^2 by an ultra-high pressure mercury lamp and heated at 100°C for 1 hour and subsequently at 150°C for 5 hours to form an interlaminar insulating material layer (adhesive layer) 12 of 35 μm in thickness provided with openings (openings 13 for the formation of viahole) having excellent dimensional precision

corresponding to the photomask film (see Fig. 6 (e)). Incidentally, the tin plated layer was partly exposed in the opening for the viahole.

(13) The substrate provided with the openings 13 for the formation of viahole was immersed in chromic acid for 20 minutes to dissolve and remove the epoxy resin particles on the surface of the adhesive layer, whereby the surface of the adhesive layer 12 was roughened at a roughened depth of $R_{\max} = 1-5 \mu\text{m}$, and then immersed in a neutralizing solution (manufactured by Shipley) and washed with water.

(14) Catalyst nuclei were applied to the surfaces of the adhesive layer 12 and the openings 13 for the formation of viahole by giving a palladium catalyst (manufactured by Atotech Co., Ltd.) to the substrate having the roughened surface (roughened depth: $3.5 \mu\text{m}$) of the adhesive layer.

(15) The substrate was immersed in an electroless copper plating bath having the same composition with the step (2) to form an electroless copper plated film 14 of $0.6 \mu\text{m}$ in thickness all over the roughened surface (see Fig. 7 (a)). At this step, since the electroless copper plated film 14 was thin, convexoconcave following the roughened surface of the adhesive layer 12 was observed on the surface of the electroless copper plated film 14.

(16) A commercially available photosensitive dry film was adhered to the electroless copper plated film 14, and a mask was placed onto the dry film, exposed to a light at 100 mJ/cm^2 and developed with a 0.8% sodium carbonate solution to form a plating resist 16 having a thickness of $15 \mu\text{m}$ (see Fig. 7 (b)).

(17) The substrate was then subjected to an electrolytic

copper plating under the same condition as in the step (6) to form an electrolytic copper plated film 15 having a thickness of 15 μm , and thereby to plate up the conductor circuits and the viaholes (see Fig. 7 (c)).

(18) After the plating resist 16 was peeled off by spraying a 5% KOH solution, the electroless plated film 15 located beneath the plating resist 16 was dissolved and removed by etching with a mixed solution of sulfuric acid and hydrogen peroxide to form conductor circuits (inclusive of viaholes) each consisting of the electroless copper plated film 14 and the electrolytic copper plated film 15 and having a thickness of 16 μm , and thereby a multilayer printed wiring board having three layers on each side was obtained (see Fig. 7 (d)). Pd remained in the roughened surface of the adhesive layer 12 was removed by immersing in chromic acid (800 g/l) for 1 to 10 minutes.

The multilayer printed wiring board prepared by the above mentioned manner ensures through-holes each provided with a perfectly circular land, and it can provide a land pitch of about 600 μm and thereby through-holes can be formed in a high density so as to densify through-holes easily. In addition, since the number of through-holes in the substrate can be increased, an electric connection with respect to conductor circuits in the multilayer core substrate can sufficiently be ensured through the through-holes.

(Example 3)

A multilayer printed wiring board was manufactured in the same manner as in Example 1, except that when through-holes were filled with a copper paste, a through-hole-

covering conductor layer 10 for covering an exposed copper paste from the through-holes was not formed. According to this process, pits might be formed because the surface of the copper paste was frequently removed in the formation of openings on an insulating resin layer by a laser beam irradiation.

(Example 4)

A multilayer printed wiring board was obtained in a similar manner to Example 1, except that the following composition was employed as the filler.

Bisphenol F type epoxy resin (manufactured by Yuka Shell Co., Ltd., E-807) 100 parts by weight

Imidazole curing agent (manufactured by Shikoku Kasei Co., Ltd., 2E4MZ-CN) 5 parts by weight

Copper powder having a particle size of 15 μ m or less (manufactured by Fukuda Metal Foil and Powder Co., Ltd., SCR-Cu-15) 735 parts by weight

Aerosil (#200) 10 parts by weight

Defoaming agent (manufactured by Sannopko, Pernol S4) 0.5 part by weight

(Comparative Example 1)

The procedure of example 1 was repeated to produce a multilayer printed wiring board, except that a bisphenol F type epoxy resin containing no metal particle was used as the filler for filling the through-hole.

(Comparative Example 2)

A multilayer printed wiring board was produced in a similar manner to Example 1, except that through-holes were filled with the epoxy resin and the surfaces of the epoxy resin exposed from the through-holes were roughened with

chromic acid and then covered with a conductor layer.

(Comparative Example 3)

A multilayer printed wiring board was obtained in the same manner as in Example 1, except that a roughened layer was not formed on the surface of the internal conductor on the through-holes.

(Results)

A heat cycle test of -55°C x 15 min., ambient temperature x 10 min. and 125°C x 15 min at 1,000 times was conducted with respect to the multilayer printed wiring boards according to the examples and comparative examples.

In addition, the presence or absence of migration of copper between through-holes was observed by conducting a PCT (pressure cooker test) under conditions of humidity of 100%, temperature of 121°C , and pressure of 2 atm for 200 hours.

As a result, viaholes could be formed just above the through-holes according to the multilayer printed wiring boards of Examples 1 to 4 of the present invention, and thus high density through-holes could easily be obtained. In addition, no peeling was observed between the filler and the internal surface conductor of the through-hole, or between the filler and the through-hole-covering conductor, and neither crack nor migration was found in the heat cycle test and PCT.

On the contrary, dispersion (migration) of copper was observed along with the glass cloth in the Teflon substrate in the multilayer printed wiring board of Comparative Example 1. Peeling of the conductor layer covering around the through-holes was observed in the multilayer printed

wiring boards of Comparative Examples 2 and 3.

(Example 5)

(1) A copper-clad laminate composed of a BT (bismaleimide-triazine) resin substrate 1 of 0.8 mm in thickness and a copper foil 2 of 18 μm in thickness having a single-sided roughened surface and laminated on the substrate 1 was used as a starting material (see Fig. 2 (a)). Initially, the copper-clad laminate was drilled (see Fig. 2 (b)), and applied with a palladium-tin colloid, and subjected to an electroless plating in the same composition and conditions as in Example 1.

Subsequently, the substrate was subjected to an electrolytic copper plating in the same conditions as in Example 1 to form an electrolytic copper plated film having a thickness of 15 μm (see Fig. 2 (c)).

(2) The substrate provided with conductors (inclusive of through-holes) consisting of an electroless copper plated film and an electrolytic copper plated film formed all over its surface was subjected to an oxidation-reduction treatment in the same conditions as in Example 1 to form a roughened layer 4 over the full surfaces of the conductors inclusive of through-holes 3 (see Fig. 2 (d)).

[Preparation of resin composition for filling through-hole]

A resin composition (filler) 5 for filling through-hole was prepared by kneading, through three rolls, 3.5 parts by weight of a cresol novolac type epoxy resin (manufactured by Yuka Shell Co., Ltd., Epikote 152), 14.1 parts by weight of a bisphenol F type epoxy resin (manufactured by Yuka Shell Co., Ltd., Epikote 807), 1.0 part by weight of ultrafine silica particles (Aerosil R202)

having an average particle size of 14 nm, 1.2 parts by weight of an imidazole curing agent (manufactured by Shikoku Kasei Co., Ltd., 2E4MZ-CN) and 100 parts by weight of copper powder having an average particle size of 15 μm , and adjusting the viscosity of the mixture to the range from 200 to 300 Pa·s at $22\pm 1^\circ\text{C}$.

(3) The prepared filler 5 was charged in the through-holes 3 by screen printing, dried and then heated at 80°C , 100°C and 120°C for each 1 hour, and at 150°C for 1 hour to cure.

Subsequently, the surface of the substrate was smoothed by removing the roughened surface positioned above the through-holes and the filler 5 protruded from the through-holes 3 by means of belt sander abrasion using a #400 belt abrasive paper (manufactured by Sankyo Rikagaku Co., Ltd.), and further buffing the substrate with alumina abrasive grains or SiC abrasive grains for removing scratches due to the belt sander abrasion (see Fig. 2 (e)).

(4) A palladium catalyst (manufactured by Atotech Co., Ltd.) was applied to the surface of the substrate smoothed in the step (3), and the substrate was subjected to an electroless copper plating in the same conditions as in Example 1 to form an electroless copper plated film 6 having a thickness of 0.6 μm (see Fig. 2 (f)).

(5) An electrolytic copper plated film 7 of 15 μm in thickness was formed by subjecting the substrate to an electrolytic copper plating according to the conditions of the step (1) to plate up portions to be conductor circuits 9 and to form a portion to be a conductor layer (to be a round through-hole land) 10 for covering the filler 5 charged in the through-hole 3.

(6) An etching resist 8 having a thickness of 15 μm was formed on both surfaces of the substrate provided with portions to be conductor circuits 9 and a conductor layer 10 in a similar manner to Example 1 (see Fig. 3 (a)).

(7) Next, the plating film positioned in a portion not provided with the etching resist 8 was dissolved and removed by etching with a solution containing a mixture of sulfuric acid and hydrogen peroxide, and the etching resist 8 was peeled off by a 5% KOH solution to form independent conductor circuits 9 and a through-hole-covering conductor layer 10 covering the filler 5 (see Fig. 3 (b)). In addition, the surfaces of the conductors inclusive of side surfaces were roughened by an oxidation-reduction treatment in a similar manner to the step (2).

[Preparation of resin filler]

①. A mixture was prepared by kneading 100 parts by weight of a bisphenol F type epoxy monomer (manufactured by Yuka Shell Co., Ltd., molecular weight: 310, YL983U), 170 parts by weight of spherical SiO_2 particles (manufactured by Admatech Co., Ltd., CRS 1101-CE, where the maximum particle size was set to below the thickness (15 μm) of an internal layer copper pattern mentioned below) coated with a silane coupling agent on their surfaces and having an average particle size of 1.6 μm , and 1.5 parts by weight of a leveling agent (manufactured by Sannopko, Pernol S4) through three rolls and adjusting a viscosity to the range from 45,000 to 49,000 cps at $23\pm 1^\circ\text{C}$.

②. Imidazole curing agent (manufactured by Shikoku Kasei Co., Ltd., 2E4MZ-CN) of 6.5 parts by weight.

An interlaminar insulating resin agent 12 was prepared by

mixing the above ingredients ① and ②.

(8) The prepared interlaminar insulating resin agent 12 was charged to gaps between the conductor circuits 9 or of the through-hole-covering conductor layer 10 by applying to one surface of the substrate through screen printing, dried at 70°C for 20 minutes. Similarly, the resin filler 12 was charged in gaps between the conductor circuits 9 or of the conductor layer 10 on the other surface of the substrate, dried at 70°C for 20 minutes. In other words, the interlaminar insulating resin agent 12 was charged between the internal layer copper patterns in this step.

(9) One surface of the substrate after the treatment of the step (8) was polished by belt sander abrasion with the use of a #400 belt abrasive paper (manufactured by Sankyo Rikagaku Co., Ltd.) so as to avoid the interlaminar insulating resin agent 12a from remaining on the surfaces of the internal layer copper patterns 9 and 10, and subsequently, buffed for removing scratches due to the belt sander abrasion. The other surface of the substrate was also subjected to a series of these polishing treatments.

Next, the interlaminar insulating resin agent 12 was cured by heating at 100°C for 1 hour, at 120°C for 3 hours, at 150°C for 1 hour and at 180°C for 7 hours.

Accordingly, both surfaces of the substrate were smoothed by removing the surface areas of the interlaminar insulating resin agent 12 charged in gaps of the conductor circuits 9 or of the through-hole-covering conductor layer 10, and the roughened layer 11 positioned above the conductor circuits 9 or the through-hole-covering layer 10 to give a substrate in which the interlaminar insulating

resin agent 12 and the conductor circuits 9 or a side surface of the through-hole-covering conductor layer 10 were firmly adhered to each other through the interposition of the roughened layer 11. That is, the surface of the interlaminar insulating resin agent 12 and those of the internal layer copper patterns could be aligned in the same plane by this step. In this step, the charged cured resin had a Tg point (glass transition point) of 155.6°C and a linear thermal expansion coefficient of $44.5 \times 10^{-6}/^{\circ}\text{C}$.

(10) A roughened layer 11 of a Cu-Ni-P alloy having a thickness of 2.5 μm was formed on the surfaces of the conductor circuits 9 and the through-hole-covering conductor layer 10 covering the filler 5, and a Sn layer having a thickness of 0.3 μm was formed on the surface of the roughened layer 11 (see Fig. 3 (c), where the Sn layer is not shown).

These layers were formed in the following manner: The substrate was acidically degreased and soft-etched, and then treated with a catalyst solution containing palladium chloride and an organic acid to apply a Pd catalyst. After activating the catalyst, the substrate was immersed in an electroless plating solution of pH of 9 containing 8 g/l of copper sulfate, 0.6 g/l of nickel sulfate, 15 g/l of citric acid, 29 g/l of sodium hypophosphite, 31 g/l of boric acid and 0.1 g/l of a surfactant to form a roughened layer 11 of a Cu-Ni-P alloy having a thickness of 2.5 μm on the surfaces of the copper conductor circuits. The substrate was then subjected to a Cu-Sn substitution reaction at a temperature of 50°C and pH of 1.2 by immersing in an electroless tin plating solution containing 0.1 mol/l of tin borofluoride

and 1.0 mol/l of thiourea for 1 hour to form a Sn layer of 0.3 μm in thickness on the surface of the roughened layer (the Sn layer is not shown).

(11) Adhesives A and B for electroless plating were prepared in the following manner.

A. Preparation of adhesive A for upper-layer electroless plating

①. To 35 parts by weight of a 25% acrylated product of a cresol novolac type epoxy resin (manufactured by Nippon Kayaku Co., Ltd., molecular weight: 2,500) were added 3.15 parts by weight of a photosensitive monomer (manufactured by Toa Gosei Co., Ltd., Aronix M315), 0.5 part by weight of a defoaming agent (manufactured by Sannopko, S-65) and 3.6 parts by weight of NMP, and the resultant mixture was admixed while stirring.

②. A mixture of 12 parts by weight of polyether sulfone (PES), 7.2 parts by weight of epoxy resin particles (manufactured by Sanyo Kasei Co., Ltd., Polymerpole) having an average particle size of 1.0 μm , 3.09 parts by weight of the epoxy resin particles having an average particle size of 0.5 μm was stirred. Subsequently, 30 parts by weight of NMP was added to the mixture and stirred and admixed by a bead mill.

③. A mixture of 2 parts by weight of an imidazole curing agent (manufactured by Shikoku Kasei Co., Ltd., 2E4MZ-CN), 2 parts by weight of a photoinitiator (manufactured by Kanto Kagaku Co., Ltd., benzophenone), 0.2 part by weight of a photosensitizer (manufactured by Hodogaya Kagaku Co., Ltd., EAB) and 1.5 parts by weight of NMP was admixed by stirring.

An adhesive A for upper-layer electroless plating was

prepared by mixing the above mixtures ① to ③.

B. Preparation of insulative adhesive B for lower-layer electroless plating

①. To 35 parts by weight of a 25% acrylated product of a cresol novolac type epoxy resin (manufactured by Nippon Kayaku Co., Ltd., molecular weight: 2,500) were added 4 parts by weight of a photosensitive monomer (manufactured by Toa Gosei Co., Ltd., Aronix M315), 0.5 part by weight of a defoaming agent (manufactured by Sannopko, S-65) and 3.6 parts by weight of NMP, and the resultant mixture was stirred.

②. After admixing 12 parts by weight of polyether sulfone (PES) and 14.49 parts by weight of epoxy resin particles (manufactured by Sanyo Kasei Co., Ltd., Polymerpole) having an average particle size of 0.5 μm , 20 parts by weight of NMP was added to the mixture and the resultant mixture was stirred and mixed by a bead mill.

③. A mixture of 2 parts by weight of an imidazole curing agent (manufactured by Shikoku Kasei Co., Ltd., 2E4MZ-CN), 2 parts by weight of a photoinitiator (manufactured by Kanto Kagaku Co., Ltd., benzophenone), 0.2 part by weight of a photosensitizer (manufactured by Hodogaya Kagaku Co., Ltd., EAB) and 1.5 parts by weight of NMP was admixed while stirring.

An adhesive B for lower-layer electroless plating was prepared by admixing the above mixtures ① to ③.

(12) Initially, the insulative adhesive B for electroless plating (viscosity: 1.5-3.2 Pa·s) and the adhesive A for electroless plating (viscosity: 5-20 Pa·s) each prepared in the step (11) were applied in turn to both surfaces of the

substrate using a roll coater, allowed to stand in a horizontal position for 20 minutes and dried at 60°C for 30 minutes to form an adhesive layer 12 (two-layer structure) having a thickness of 40 μm (see Fig. 3 (d)). Further, a polyethylene terephthalate film was applied onto the adhesive layer 12 through a pressure-sensitive adhesive.

(13) A photomask film printed with a full circle of 85 μm in diameter was closely adhered to the adhesive layer 12 formed on both surfaces of the substrate, and exposed to an irradiation at 500 mJ/cm^2 by an ultra-high pressure mercury lamp. The exposed substrate was developed by spraying a DMDG (diethylene glycol dimethyl ether) solution to form openings for viahole of 85 μm in diameter on the adhesive layer. The substrate was further exposed to an irradiation by an ultra-high pressure mercury lamp at 3,000 mJ/cm^2 and heated at 100°C for 1 hour and subsequently at 150°C for 5 hours to form an interlaminar insulating material layer (adhesive layer) 12 of 35 μm in thickness provided with openings (openings 13 for the formation of viahole) having an excellent dimensional precision corresponding to the photomask film (see Fig. 3 (e)). Incidentally, the tin plated layer was partly exposed in the openings for viahole.

(14) The substrate provided with the openings 13 for the formation of viahole was immersed in chromic acid for 19 minutes to dissolve and remove the epoxy resin particles on the surface of the adhesive layer, whereby the surface of the adhesive layer was roughened at a roughened depth of $R_{\text{max}} = 1\text{-}5 \mu\text{m}$, and then immersed in a neutralizing solution (manufactured by Shipley) and washed with water.

(15) Catalyst nuclei were applied to the surfaces of the

adhesive layer 12 and the openings 13 for the formation of viahole by giving a palladium catalyst (manufactured by Atotech Co., Ltd.) to the substrate having the roughened surface (roughened depth: 3 μm) of the adhesive layer.

(16) The substrate was immersed in an electroless copper plating bath having the same composition with the step (1) to form an electroless copper plated film of 0.6 μm in thickness all over the roughened surface (see Fig. 4 (a)).

At this step, since the electroless plated film was thin, unevenness was observed on the surface of the electroless plated film.

(17) A commercially available photosensitive resin film (dry film) was adhered to the electroless copper plated film 14, and a mask was closely placed onto the dry film, exposed to a light irradiation at 100 mJ/cm^2 and developed with a 0.8% sodium carbonate solution to form a plating resist 16 having a thickness of 15 μm (see Fig. 4 (b)).

(18) The substrate was then subjected to an electrolytic copper plating under the same condition as the step (1) to form an electrolytic copper plated film 15 having a thickness of 15 μm and thereby to plate up the conductor circuit portions and viahole portions (see Fig. 4 (c)).

(19) After the plating resist 16 was peeled off through a 5% KOH solution, the electroless plated film 15 located beneath the plating resist 16 was dissolved and removed by etching with a mixed solution of sulfuric acid and hydrogen peroxide to form conductor circuits 9 (inclusive of viaholes 17) consisting of the electroless copper plated film 14 and the electrolytic copper plated film 15 and having a thickness of 16 μm (see Fig. 4 (d)).

(20) The substrate provided with the conductor circuits 9 (inclusive of viaholes 17) in the step (19) was immersed in an electroless plating solution of pH of 9 containing 8 g/l of copper sulfate, 0.6 g/l of nickel sulfate, 15 g/l of citric acid, 29 g/l of sodium hypophosphite, 31 g/l of boric acid and 0.1 g/l of a surfactant to form a roughened layer 11 of copper-nickel-phosphorus having a thickness of 3 μm on the surface of the conductor circuits. In this case, the roughened layer 11 contained 98% by mole of Cu, 1.5% by mole of Ni and 0.5% by mole of P as analyzed by EPMA (electron probe microanalysis; fluorescent X-ray analysis).

Further, the substrate was washed with water and immersed in an electroless tin substitution plating bath containing 0.1 mol/l of tin borofluoride and 1.0 mol/l of thiourea at 50°C for 1 hour to form a tin substitution plated layer of 0.05 μm in thickness on the surface of the roughened layer 11 (where tin substituted layer is not shown).

(21) Further, each one layer of an upper interlaminar insulating resin layer 12 and a conductor circuit 9 (inclusive of viahole 17) was laminated by repeating the steps (12) to (20) to obtain a multilayer circuit substrate (see Fig. 8 (a)). In this step, a roughened layer 11 composed of copper-nickel-phosphorus was formed on the surface of the conductor circuit, but a tin substitution plated layer was not formed on the surface of the roughened layer 11.

(22) On the other hand, a solder resist composition was prepared by mixing 46.67 parts by weight of a photosensitized oligomer (molecular weight: 4,000) obtained

by acrylating 50% of epoxy groups of a cresol novolac type epoxy resin (manufactured by Nippon Kayaku Co., Ltd.) as a 60% by weight solution in DMDG, 14.121 parts by weight of a bisphenol A type epoxy resin (manufactured by Yuka Shell Co., Ltd., trade name: Epikote 1001) as a 80% by weight solution in methyl ethyl ketone, 1.6 parts by weight of an imidazole curing agent (manufactured by Shikoku Kasei Co., Ltd., 2E4MZ-CN), 1.5 parts by weight of a polyvalent acrylic monomer (manufactured by Nippon Kayaku Co., Ltd., R604) as a photosensitive monomer, 3.0 parts by weight of a polyvalent acrylic monomer (manufactured by Kyoeisha Chemical Co., Ltd., DPE6A), and 0.36 part by weight of a leveling agent (manufactured by Kyoeisha Chemical Co., Ltd., Polyflow No. 75) composed of an acrylic ester polymer, adding 2.0 parts by weight of benzophenone (manufactured by Kanto Kagaku Co., Ltd.) as a photoinitiator and 0.2 part by weight of EAB (manufactured by Hodogaya Kagaku Co., Ltd.) as a photosensitizer, and 1.0 part by weight of DMDG (diethylene glycol dimethyl ether) to the mixture and adjusting a viscosity to 1.4 ± 0.3 Pa·s at 25°C.

The viscosity was measured by B-type viscometer (manufactured by Tokyo Keiki Co., Ltd., model: DVL-B) using a rotor No. 4 at 60 rpm and a rotor No. 3 at 6 rpm.

(23) The above solder resist composition was applied to both surfaces of the multilayer wiring substrate obtained in the step (21) at a thickness of 20 μm . Then it was dried at 70°C for 20 minutes and at 70°C for 30 minutes and thereafter a soda-lime glass substrate of 5 mm in thickness depicted with circle patterns (mask patterns) for solder resist openings through chromium layer was closely placed on the

solder resist layer so as to face the chromium layer side thereto, exposed to an ultraviolet ray irradiation at 1,000 mJ/cm² and developed with DMTG. Further, it was heated at 80°C for 1 hour, at 100°C for 1 hour, at 120°C for 1 hour and at 150°C for 3 hours to form a pattern of solder resist layer 18 (thickness: 20 μm) having an opening (opening size: 200 μm) in the solder pad.

(24) The substrate provided with the solder resist layer 18 was immersed for 20 minutes in an electroless nickel plating solution of pH of 5 containing 30 g/l of nickel chloride, 10 g/l of sodium hypophosphite and 10 g/l of sodium citrate to form a nickel plated layer 19 having a thickness of 5 μm in the opening. The substrate was then immersed in an electroless gold plating solution containing 2 g/l of potassium gold cyanide, 75 g/l of ammonium chloride, 50 g/l of sodium citrate and 10 g/l of sodium hypophosphite at 93°C for 23 seconds to form a gold plated layer 20 of 0.03 μm in thickness on the nickel plated layer 19.

(25) A solder paste was printed on the opening of the solder resist layer and reflowed at 200°C to form a solder bump (solder body), thereby a multilayer printed wiring board having solder bumps was obtained (see Fig. 8 (b)).

Incidentally, tin-silver, tin-indium, tin-zinc, tin-bismuth or other solders can be employed as the solder.

(Comparative Example 4) [Without the use of ultrafine silica particles]

A multilayer printed wiring board was produced in a similar manner to Example 1, except that the following composition was used as the resin composition for filling through-hole.

To be more specific, a resin composition for filling through-hole was prepared by kneading through three rolls 3.5 parts by weight of a cresol novolac type epoxy resin (manufactured by Yuka Shell Co., Ltd., Epikote 152), 14.1 parts by weight of a bisphenol F type epoxy resin (manufactured by Yuka Shell Co., Ltd., Epikote 807), 1.2 parts by weight of an imidazole curing agent (manufactured by Shikoku Kasei co., Ltd., 2E4MZ-CN) and 100 parts by weight of copper powder having an average particle size of 15 μm , and adjusting a viscosity to the range from 200 to 300 Pa·s at 22 $\pm$ 1°C.

(Example 6) [Bisphenol type epoxy resin only]

The procedure of Example 1 was repeated to give a multilayer printed wiring board, except that the following resin composition was employed as the resin composition for filling through-hole.

To be more specific, a resin composition for filling through-hole was prepared by mixing 17.6 parts by weight of a bisphenol F type epoxy resin (manufactured by Yuka Shell Co., Ltd., Epikote 807), 1.0 part by weight of ultrafine silica particles (Aerosil R202) having an average particle size of 14 nm, 1.2 parts by weight of an imidazole curing agent (Shikoku Kasei Co., Ltd., 2E4MZ-CN) and 100 parts by weight of copper powder having an average particle size of 15 μm .

(Example 7) [Silica particle]

A multilayer printed wiring board was prepared in the same manner as in Example 1, except that the following resin composition was used as the resin composition for filling through-hole.

That is, a resin composition for filling through-hole was prepared by kneading, through three rolls, 3.5 parts by weight of a cresol novolac type epoxy resin (manufactured by Yuka Shell Co., Ltd., Epikote 152), 1.0 part by weight of ultrafine silica particles (Aerosil R202) having an average particle size of 14 nm, 14.1 parts by weight of a bisphenol F type epoxy resin (manufactured by Yuka Shell Co., Ltd., Epikote 807), 1.2 parts by weight of an imidazole curing agent (manufactured by Shikoku Kasei Co., Ltd., 2E4MZ-CN) and 100 parts by weight of silica particles having an average particle size of 10 μm , and adjusting a viscosity to the range from 200 to 300 Pa·s at 22 $\pm$ 1°C.

(Example 8) [Epoxy resin particle]

A multilayer printed wiring board was produced in a similar manner to Example 1, except that the following resin composition for filling through-hole was used and that after polishing the surface of the filler, the epoxy resin exposed from the surface was removed by chromic acid.

To be more specific, a resin composition for filling through-hole was prepared by kneading through three rolls 3.5 parts by weight of a cresol novolac type epoxy resin (manufactured by Yuka Shell Co., Ltd., Epikote 152), 14.1 parts by weight of a bisphenol F type epoxy resin (manufactured by Yuka Shell Co., Ltd., Epikote 807), 1.0 part by weight of ultrafine silica particles (Aerosil R202) having an average particle size of 14 nm, 1.2 parts by weight of an imidazole curing agent (manufactured by Shikoku Kasei Co., Ltd., 2E4MZ-CN) and 100 parts by weight of epoxy resin particles (manufactured by Sanyo Kasei Co., Ltd., Polymerpole) having an average particle size of 1 μm , and

adjusting the viscosity of the mixture to the range from 200 to 300 Pa·s at 22±1°C.

(Comparative Example 5) [Without particulate substance]

The procedure of Example 1 was repeated to give a multilayer printed wiring board, except that the following resin composition was employed as the resin composition for filling through-hole.

That is, a resin composition for filling through-hole containing 3.5 parts by weight of a cresol novolac type epoxy resin (manufactured by Yuka Shell Co., Ltd., Epikote 152), 14.1 parts by weight of a bisphenol F type epoxy resin (manufactured by Yuka Shell Co., Ltd., Epikote 807), 1.2 parts by weight of an imidazole curing agent (manufactured by Shikoku Kasei Co., Ltd., 2E4MZ-CN) and 1.0 part by weight of a colloidal silica (Aerosil R202) having an average particle size of 14 nm was prepared.

Whether a break between a through-hole and a viahole caused by peeling or the like was formed or not was confirmed by conducting PCT (Pressure Cooker Test) in conditions of relative humidity of 100%, temperature of 121°C and pressure of 2 atm for 200 hours with respect to the multilayer printed wiring boards of the examples and comparative examples. After the completion of PCT, the wiring boards were subjected to a heating test at 128°C for 48 hours.

(Results)

No peeling of the conductor layer covering the filler, and no break caused by the peeling was observed in the wiring boards according to Examples 5 to 8, whereas the peeling, break and/or contact failure was observed in the

wiring boards according to Comparative Examples 4 and 5.

To be more specific, in the wiring board according to Comparative Example 4 where ultrafine silica particles were not used, the copper powder precipitated so as to cause the filler to peel from the conductor layer covering the filler, and thereby to invite a break between the through-hole and viahole.

In addition, a part of the bisphenol F type epoxy resin flowed out of the through-hole due to viscosity fall in curing, and an indentation was formed on the surface of the filler. When a conductor layer covering the filler was formed above the indentation, a crevice was formed in the center of the conductor layer. Thus, even when a resin was applied and polished to smooth the surface of the substrate, the resin remained in the central crevice, and a connection to the viahole could not be established.

In the wiring board according to Comparative Example 5, the cured filler and the conductor layer covering the filler were never adhered to each other so as to cause peeling and hence a break between the through-hole and the conductor layer.

No peeling was observed in the wiring boards according to Examples 5 and 6, whereas a peeling was observed in the wiring boards according to Examples 7 and 8. It is estimated that peeling does not occur in the wiring boards of Examples 5 and 6 because the copper powder was completely integrated with the conductor layer.

Industrial Applicability

As described above, the printed wiring board according to the invention is useful for a multilayer wiring board

which is used as a packaging substrate for packing IC chips, in particular for a multilayer printed wiring board obtained by a semi-additive process or a full-additive process. In addition, the resin composition according to the invention is applicable as through-holes, as well as an interlaminar insulating resin layer of a printed wiring board.



CLAIMS

1. A multilayer printed wiring board being composed of a substrate provided with through-holes, and a conductor circuit formed on the substrate through the interposition of an interlaminar insulating resin layer, said through-holes being filled with a filler, wherein

an internal surfaces of the through-holes are roughened.

2. The multilayer printed wiring board according to Claim 1, wherein the filler is composed of metal particles and a thermosetting resin or a thermoplastic resin.

3. The multilayer printed wiring board according to Claim 1, wherein the filler is composed of a particulate substance, a resin and an ultrafine inorganic powder.

4. The multilayer printed wiring board according to Claim 3, wherein the filler is a nonconducting composition containing metal particles.

5. The multilayer printed wiring board according to Claim 3, wherein the particulate substance is composed of at least one member selected from metal particles, inorganic particles and resin particles.

6. The multilayer printed wiring board according to Claim 3, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.

7. The multilayer printed wiring board according to Claim 1, wherein the substrate is a multilayer core substrate formed by laminating a conductor layer and a prepreg in alternating order.



8. The multilayer printed wiring board according to Claim 1, wherein the through-holes formed on the substrate have a pitch interval of equal to or less than 700 μm .

9. The multilayer printed wiring board according to Claim 1, wherein build-up wiring layers formed on both surfaces of the substrate have the same number of layers with each other and the wiring thereof is installed dispersing to the periphery of the substrate.

10. A multilayer printed wiring board being composed of a substrate provided with through-holes, and a conductor circuit formed on the substrate through the interposition of an interlaminar insulating resin layer, said through-holes being filled with a filler, wherein

an exposed portion of the filler in the through-holes is covered with a through-hole-covering conductor layer.

11. The multilayer printed wiring board according to Claim 10, wherein the internal surfaces of the through-holes are roughened.

12. The multilayer printed wiring board according to Claim 10, wherein a roughened layer is formed on the surface of the through-hole-covering conductor layer.

13. The multilayer printed wiring board according to Claim 10, wherein the filler is composed of metal particles, and a thermosetting resin or a thermoplastic resin.

14. The multilayer printed wiring board according to Claim 10, wherein the filler is composed of a particulate substance, a resin and an ultrafine inorganic powder.

15. The multilayer printed wiring board according to Claim 14, wherein the filler is a nonconducting composition containing metal particles.





16. The multilayer printed wiring board according to Claim 14, wherein the particulate substance is composed of at least one member selected from metal particles, inorganic particles and resin particles.

17. The multilayer printed wiring board according to Claim 14, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.

18. The multilayer printed wiring board according to Claim 10, wherein the substrate is a multilayer core substrate formed by laminating a conductor layer and a prepreg in alternating order.

19. The multilayer printed wiring board according to Claim 10, wherein the through-holes formed on the substrate have a pitch interval of equal to or less than 700 μm .

20. The multilayer printed wiring board according to Claim 10, wherein build-up wiring layers formed on both surfaces of the substrate have the same number of layers with each other and the wiring thereof is installed dispersing to the periphery of the substrate.

21. A multilayer printed wiring board being composed of a substrate provided with through-holes, and a conductor circuit formed on the substrate through the interposition of an interlaminar insulating resin layer, said through-holes being filled with a filler, wherein

an exposed surface of the filler in the through-holes is covered with a through-hole-covering conductor layer, and a viahole formed just above the conductor layer is connected to the through-hole-covering conductor layer.

22. The multilayer printed wiring board according to





Claim 21, wherein the internal surfaces of the through-holes are roughened.

23. The multilayer printed wiring board according to Claim 21, wherein a roughened layer is formed on the surface of the through-hole-covering conductor layer.

24. The multilayer printed wiring board according to Claim 21, wherein the filler is composed of metal particles, and a thermosetting resin or a thermoplastic resin.

25. The multilayer printed wiring board according to Claim 21, wherein the filler is composed of a particulate substance, a resin and an ultrafine inorganic powder.

26. The multilayer printed wiring board according to Claim 25, wherein the filler is a nonconducting composition containing metal particles.

27. The multilayer printed wiring board according to Claim 25, wherein the particulate substance is composed of at least one member selected from metal particles, inorganic particles and resin particles.

28. The multilayer printed wiring board according to Claim 25, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.

29. The multilayer printed wiring board according to Claim 21, wherein the substrate is a multilayer core substrate formed by laminating a conductor layer and a prepreg in alternating order.

30. The multilayer printed wiring board according to Claim 21, wherein the through-holes formed on the substrate have a pitch interval of equal to or less than 700 μm .

31. The multilayer printed wiring board according to





Claim 21, wherein build-up wiring layers formed on both surfaces of the substrate have the same number of layers with each other and the wiring thereof is installed dispersing to the periphery of the substrate.

32. A process of producing a multilayer printed wiring board comprising at least the following steps ① to ④:

① a step of forming a conductor layer and through-holes on both surfaces of a substrate by electroless plating, or additionally electroplating,

② a step of forming a roughened layer on the surfaces of the through-holes,

③ a step of filling the through-holes each having the roughened layer on its internal surface with a filler,

④ a step of forming an interlaminar insulating resin layer and then forming a conductor circuit by subjecting to an electroless plating, or additionally to an electroplating.

33. The process according to Claim 32, wherein the internal surfaces of the through-holes are roughened by any process selected from an oxidation-reduction treatment, a treatment with an aqueous mixed solution of an organic acid and a copper(II) complex, and a plating with a needle ternary alloy of copper-nickel-phosphorus.

34. The process according to Claim 32, wherein the step of filling the through-holes with a filler is conducted by filling the through-holes with a filler composed of metal particles, and a thermosetting resin or a thermoplastic resin, and drying and curing the filler.

35. The process according to Claim 32, wherein the step of filling the through-holes with a filler is conducted





by filling the through-holes with a filler composed of a particulate substance, a resin and an ultrafine inorganic powder, and drying and curing the filler.

36. The process according to Claim 35, wherein the step of filling the through-holes with a filler is conducted by filling the through-holes with a filler composed of a nonconducting composition containing metal particles, and drying and curing the filler.

37. The process according to Claim 35, wherein the particulate substance is composed of at least one member selected from metal particles, inorganic particles and resin particles.

38. The process according to Claim 35, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.

39. A process of producing a multilayer printed wiring board comprising at least the following steps ① to ④:

① a step of forming a conductor layer and through-holes on both surfaces of a substrate by electroless plating, or additionally by electroplating,

② a step of filling the through-holes with a filler,

③ a step of forming a through-hole-covering conductor layer by subjecting an exposed portion of the filler on the through-holes to an electroless plating, or additionally to an electroplating, and

④ a step of forming an interlaminar insulating resin layer and then forming a conductor circuit by electroless plating, or additionally by electroplating.

40. The process according to Claim 39, wherein the





through-holes have been provided with a roughened layer on the internal surfaces thereof.

41. The process according to Claim 40, wherein the internal surfaces of the through-holes are roughed by any process selected from an oxidation-reduction treatment, a treatment with an aqueous mixed solution of an organic acid and a copper(II) complex, and a plating treatment with a needle-formed ternary alloy of copper-nickel-phosphorus.

42. The process according to Claim 39, wherein the filling step of a filler is conducted by filling the through-holes with a filler composed of metal particles and a thermosetting resin or a thermoplastic resin, and drying and curing the filler.

43. The process according to Claim 39, wherein the filling step of a filler is conducted by filling the through-holes with a filler composed of a particulate substance, a resin and an ultrafine inorganic powder, and drying and curing the filler.

44. The process according to Claim 43, wherein the filling step of a filler is conducted by filling the through-holes with a filler composed of a nonconducting composition having a specific resistance of equal to or more than $1 \times 10^6 \Omega \cdot \text{cm}^2$ and containing metal particles, and drying and curing the filler.

45. The process according to Claim 43, wherein the particulate substance is at least one member selected from metal particles, inorganic particles and resin particles.

46. The process according to Claim 43, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.





* C L M S *

47. The process according to Claim 39, wherein the step of forming the through-hole-covering conductor layer is conducted by applying catalyst nuclei to the surface of the substrate being previously smoothed, subjecting the substrate to an electroless plating, or additionally to an electroplating, then forming an etching resist just above the through-holes and a portion to be a conductor circuit, removing the plating layer in a portion where the etching resist is not formed, and further peeling off the etching resist on the through-hole-covering conductor layer and the conductor circuit portion.

48. The process according to Claim 39, wherein the step of forming the through-hole-covering conductor layer is conducted by forming a plating resist in a given position on the surface of the substrate being previously smoothed and then subjecting a portion where the resist is not formed to an electroplating to form a through-hole-covering conductor layer and a conductor circuit, and removing the plating resist with the plating film located beneath the resist by etching.

49. The process according to Claim 39, wherein the step of forming a through-hole-covering conductor layer comprises a step of roughening the surface of the through-hole-covering conductor layer by any process selected from an oxidation-reduction treatment, a treatment with an aqueous mixed solution of an organic acid and a copper(II) complex and a plating treatment with a needle-formed ternary alloy of copper-nickel-phosphorus.

50. A process of producing a multilayer printed wiring board comprising at least the following steps ① to





⑥:

① a step of forming a conductor layer and through-holes on both surfaces of a substrate by electroless plating, or additionally by electroplating,

② a step of forming a roughened layer in the internal surfaces of the through-holes,

③ a step of filling the through-holes provided with a roughened layer with a filler,

④ a step of forming a through-hole-covering conductor layer on an exposed portion of the filler on the through-holes by electroless plating, or additionally by electroplating,

⑤ a step of forming an interlaminar insulating resin layer, and

⑥ a step of forming a viahole and a conductor circuit in the interlaminar insulating resin layer located just above the through-holes, and connecting the viahole to the through-hole-covering conductor layer.

51. The process according to Claim 50, wherein the internal surfaces of the through-holes are roughened by any process selected from an oxidation-reduction treatment, a treatment with an aqueous mixed solution of an organic acid and a copper(II) complex, or a plating treatment with a needle-formed ternary alloy of copper-nickel-phosphorus.

52. The process according to Claim 50, wherein the filling step of a filler is conducted by filling the through-holes with a filler composed of metal particles and a thermosetting resin or a thermoplastic resin, and drying and curing the filler.

53. The process according to Claim 50, wherein the





filling step of a filler is conducted by filling the through-holes with a filler composed of a particulate substance, a resin and an ultrafine inorganic powder, and drying and curing the filler.

54. The process according to Claim 50, wherein the filling step of a filler is conducted by filling the through-holes with a filler composed of a nonconducting composition containing metal particles, and drying and curing the filler.

55. The process according to Claim 53, wherein the particulate substance is at least one member selected from metal particles, inorganic particles and resin particles.

56. The process according to Claim 53, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.

57. The process according to Claim 50, wherein the step of forming a through-hole-covering conductor layer is conducted by applying catalyst nuclei to the surface of the substrate being previously smoothed, subjecting the substrate to an electroless plating to form a plated layer, or additionally to an electroplating, then forming an etching resist just above the through-holes and a portion where the conductor circuit is formed, removing the plated layer in a portion where the etching resist is not formed, and further peeling off the etching resist on the through-hole-covering conductor layer and the conductor circuit.

58. The process according to Claim 50, wherein the step of forming a through-hole-covering conductor layer is conducted by forming a plating resist in a given position on the surface of the substrate being previously smoothed and





then subjecting a portion where the resist is not formed to an electroplating to form a through-hole-covering conductor layer and a conductor circuit, and removing the plating resist and the plated film located beneath the resist through etching.

59. The process according to Claim 50, wherein the step of forming a through-hole-covering conductor layer comprises a step of roughening the surface of the through-hole-covering conductor layer by any process selected from an oxidation-reduction treatment, a treatment with an aqueous mixed solution of an organic acid and a copper(II) complex or a plating treatment with a needle-formed ternary alloy of copper-nickel-phosphorus.

60. The process according to Claim 50, wherein a viahole is formed just above the through-hole-covering conductor layer through the interposition of an interlaminar insulating resin layer by roughening the interlaminar insulating resin layer provided with an opening for viahole, or applying catalyst nuclei directly to the resin layer without roughening, then subjecting the resin layer to an electroless plating or additionally to an electroplating, and etching the plated layer so as to remain a viahole and a conductor circuit portion.

61. A resin composition for filling through-hole of a printed wiring board being composed of a particulate substance, a resin and an ultrafine inorganic powder.

62. The resin composition according to Claim 61, which is a nonconducting composition containing metal particles.

63. The resin composition according to Claim 61,





wherein the particulate substance is composed of at least one member selected from metal particles, inorganic particles and resin particles.

64. The resin composition according to Claim 61, wherein the resin is composed of at least one member selected from a bisphenol type epoxy resin and a novolac type epoxy resin.

65. The resin composition according to Claim 64, wherein the bisphenol type epoxy resin is composed of at least one member selected from bisphenol F type epoxy resins and bisphenol A type epoxy resins.

66. The resin composition according to Claim 64, wherein the novolac type epoxy resin is composed of at least one member selected from phenol novolac type epoxy resins and cresol novolac type epoxy resins.

67. The resin composition according to Claim 64, wherein the composition ratio of the novolac type epoxy resin to the bisphenol type epoxy resin ranges from 1/1 to 1/100 by weight.

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ABSTRACT OF THE DISCLOSURE

A multilayer printed wiring board is composed of a substrate provided with through-holes, and a wiring board formed on the substrate through the interposition of an interlaminar insulating resin layer, the through-holes having a roughened internal surface and being filled with a filler, an exposed part of the filler in the through-holes being covered with a through-hole-covering conductor layer, and a viahole formed just thereabove being connected to the through-hole-covering conductor layer.

Without peeling between the through-holes and the filler, this wiring board has a satisfactory connection reliability between the through-holes and the internal layer circuit and provides a high density wiring.

Fig. 1

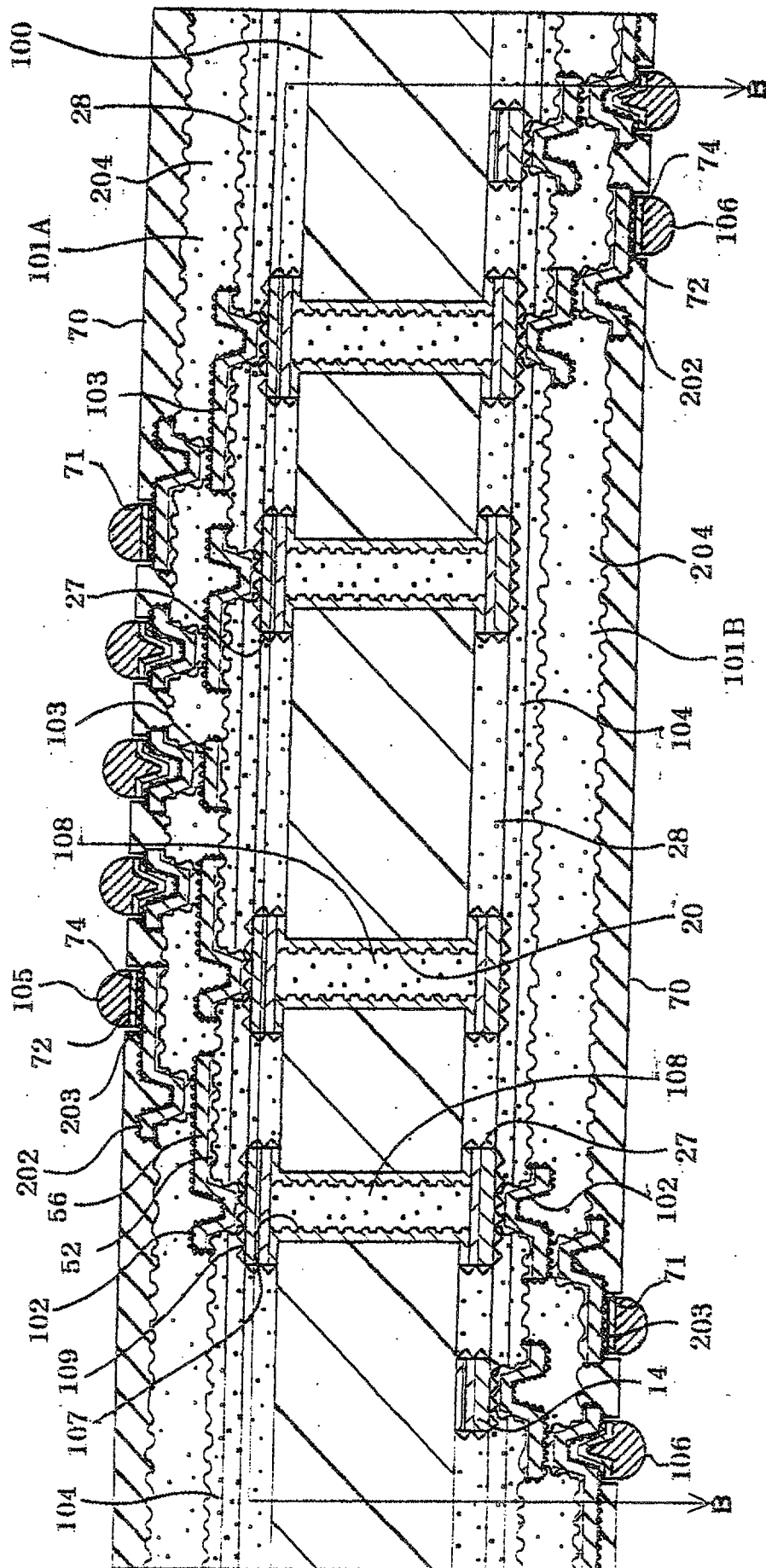


Fig.2

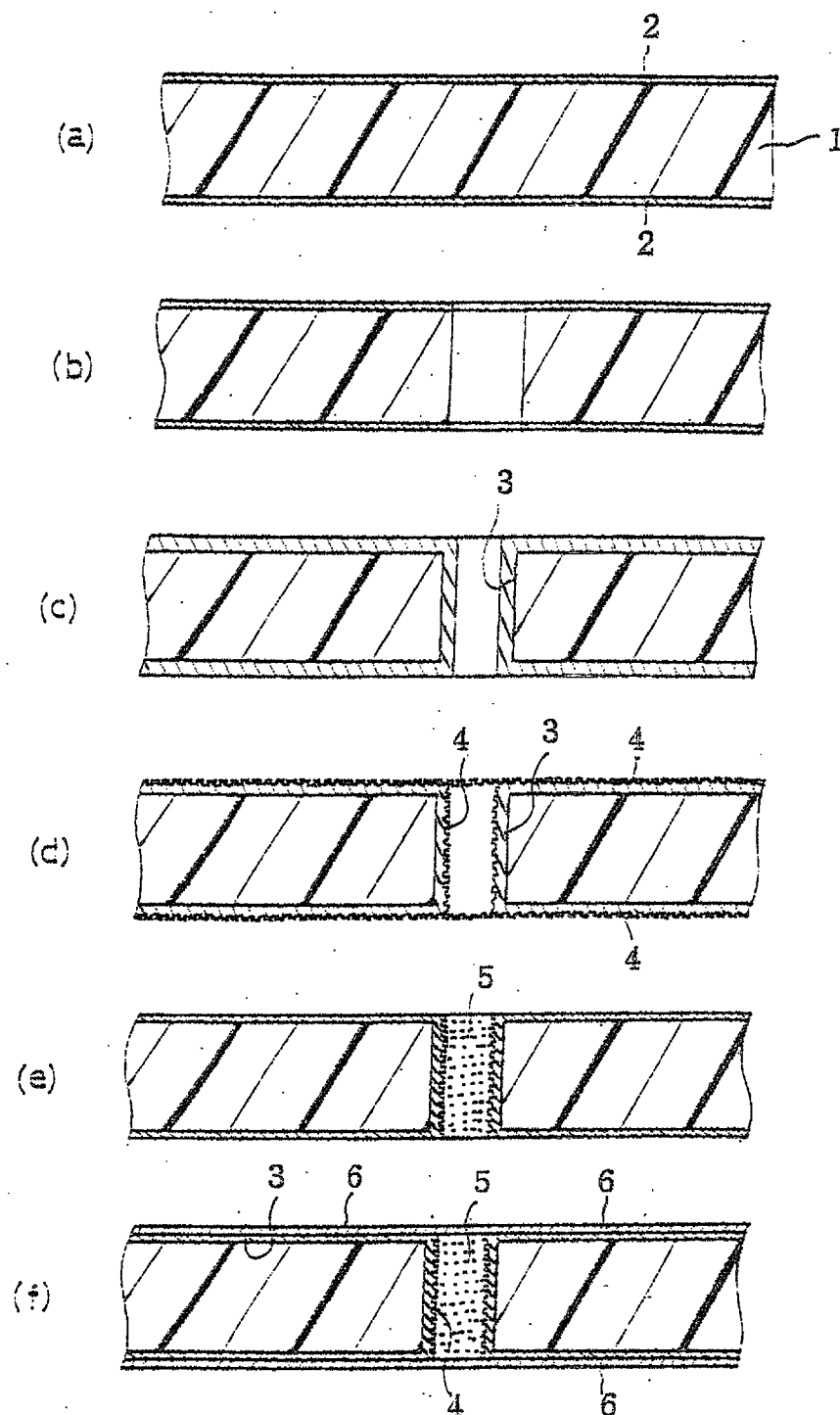


Fig. 3

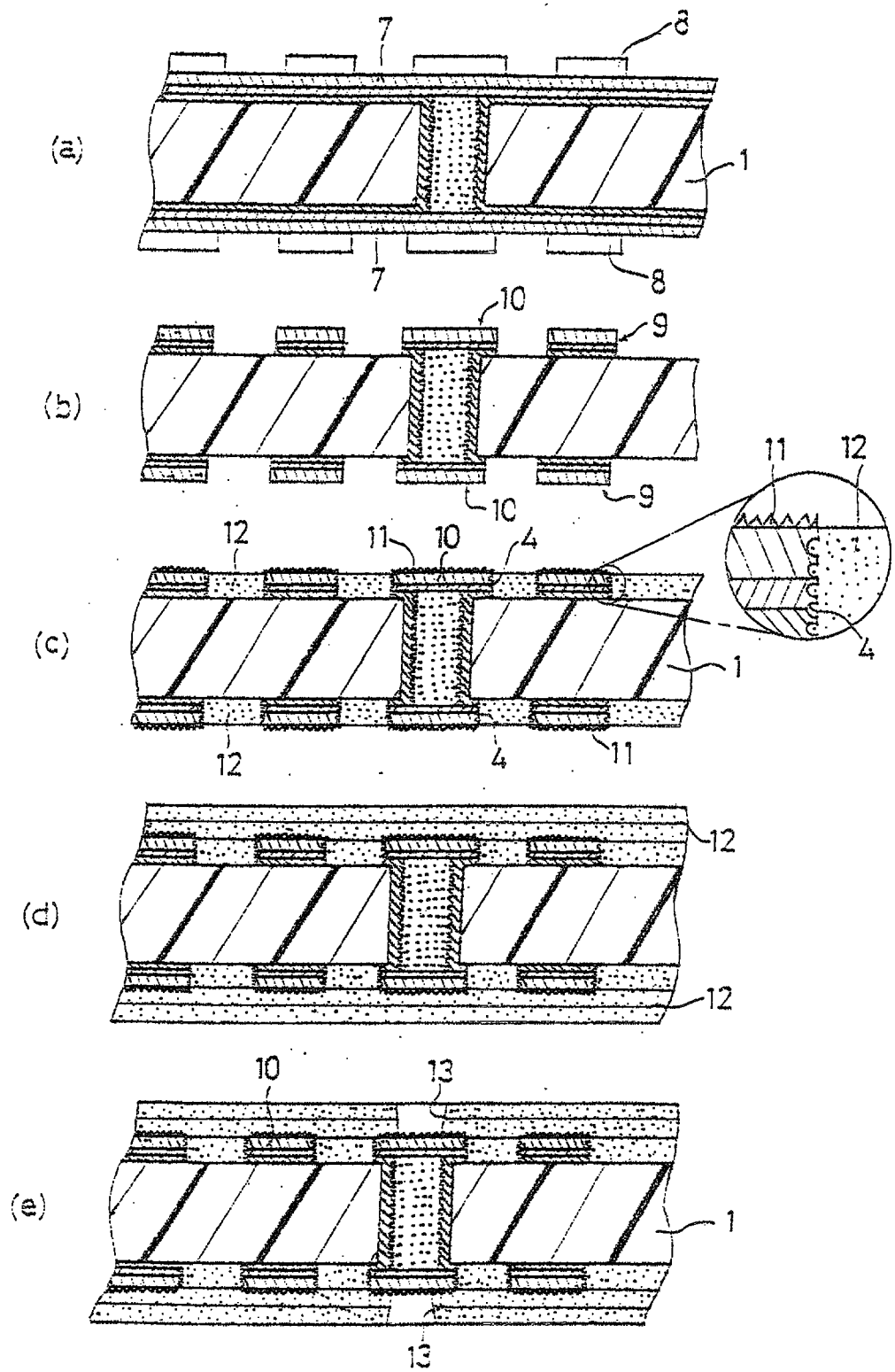


Fig. 4

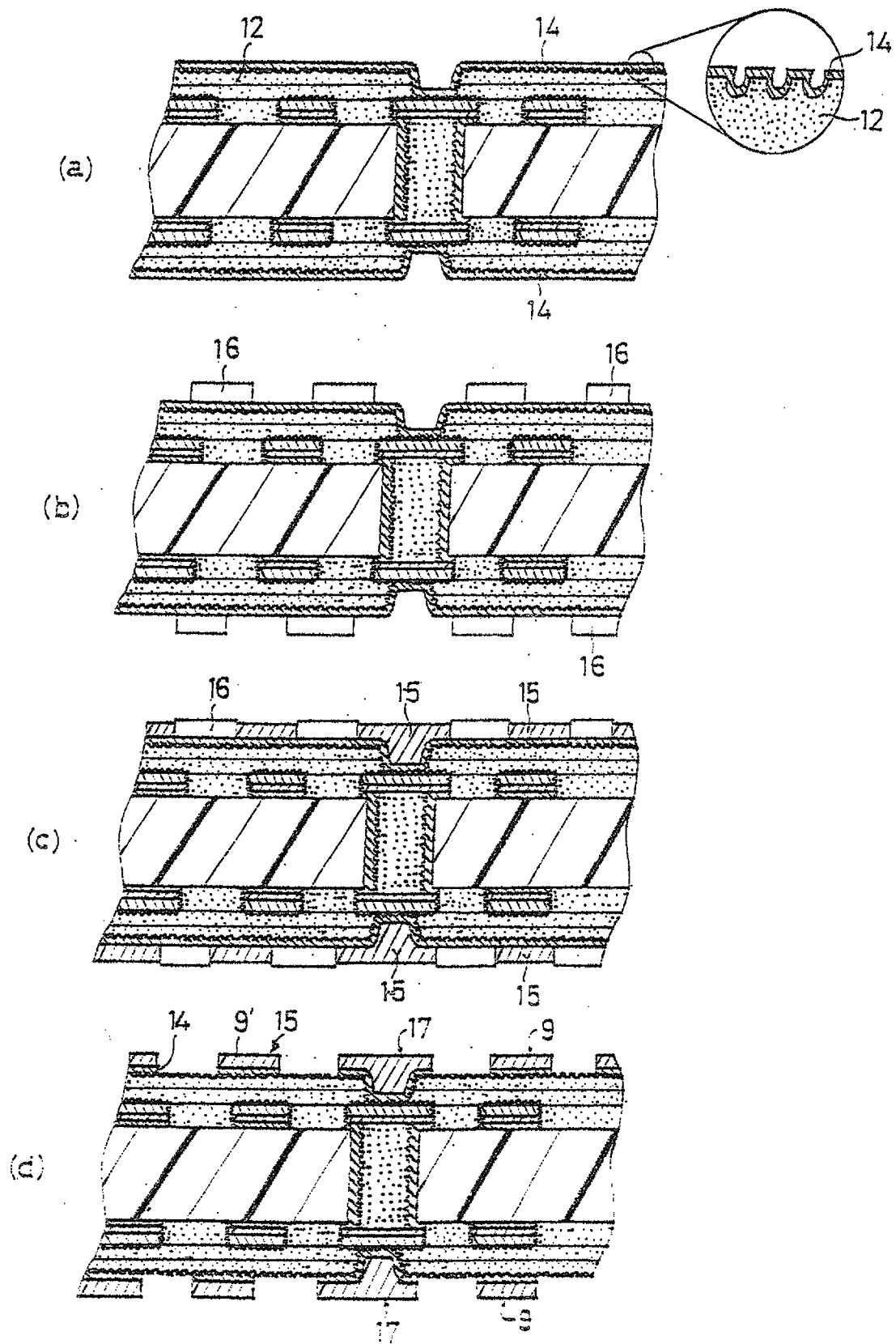


Fig. 5

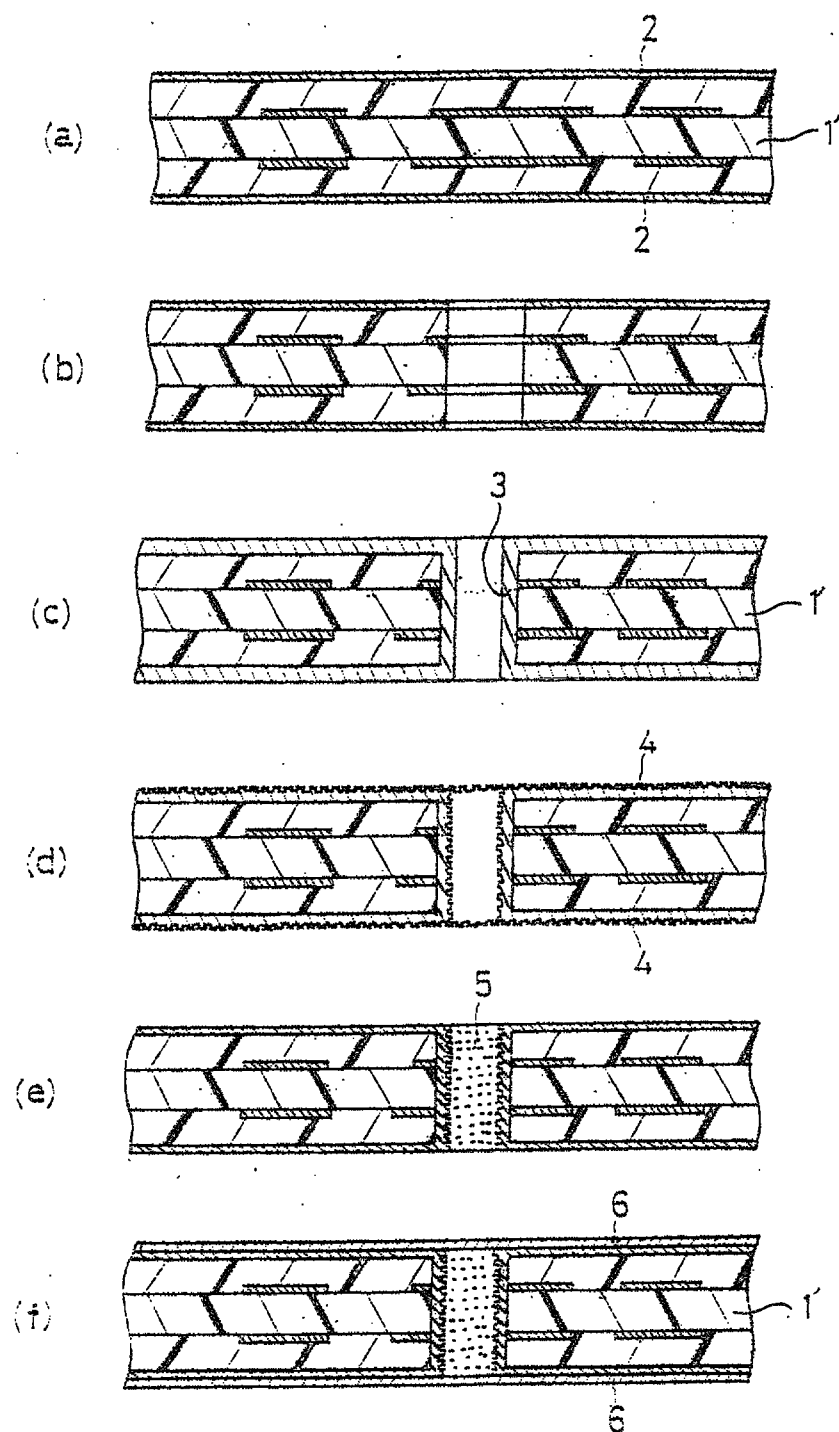


Fig. 6

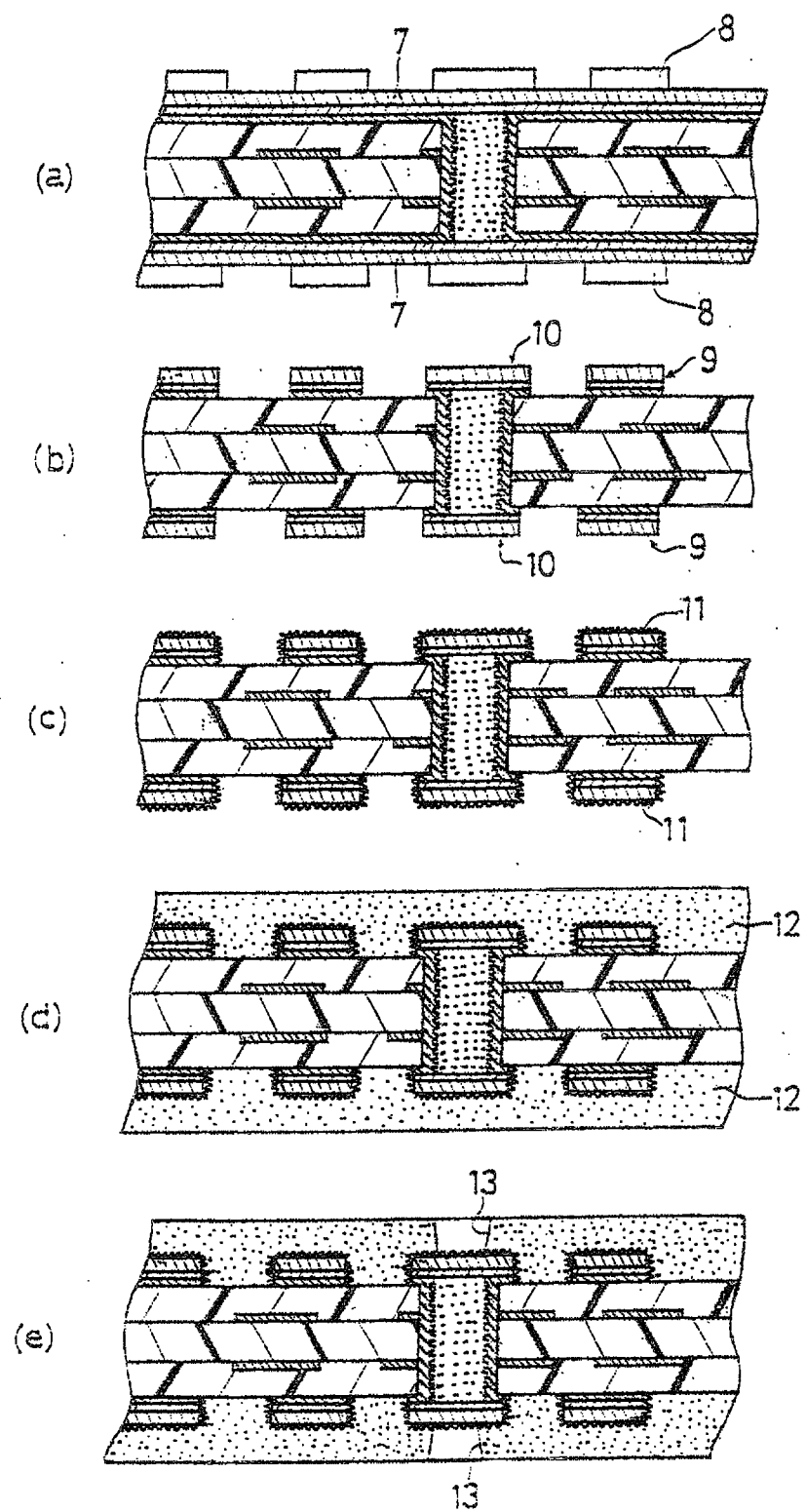


Fig. 7

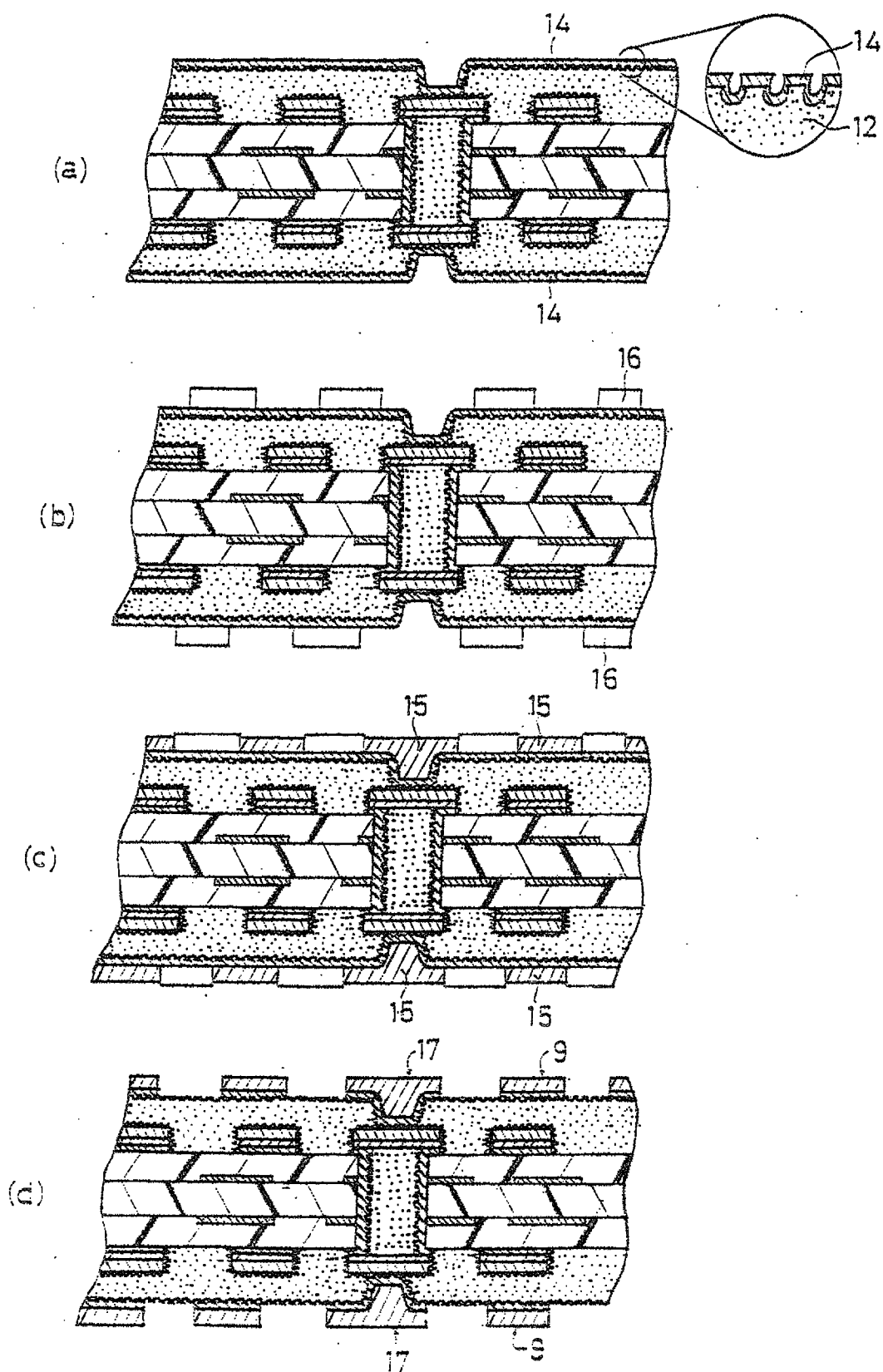
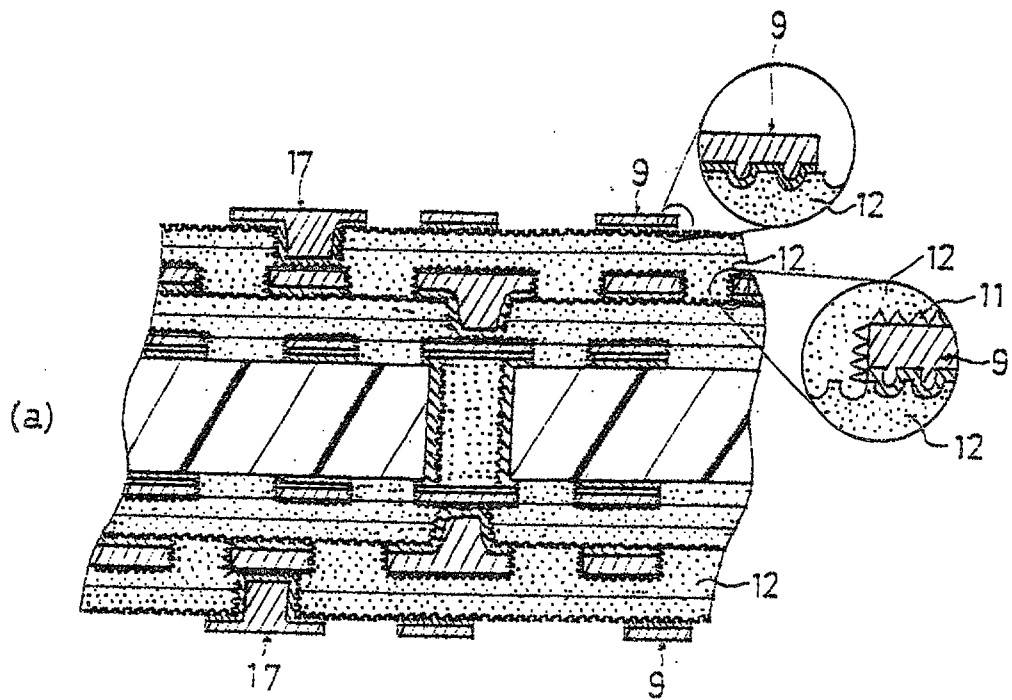
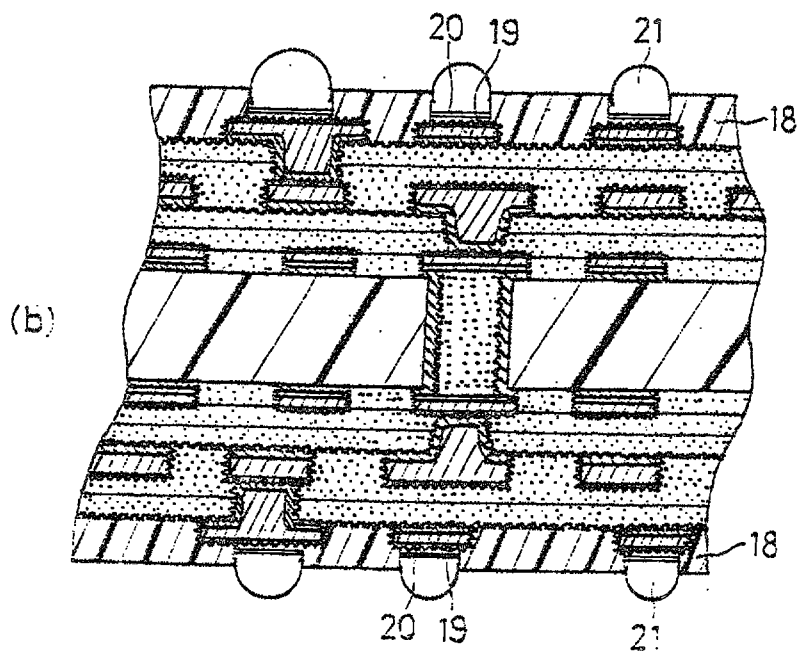


Fig. 8



through-hole of the aforementioned multilayer printed wiring boards.

Disclosure of Invention

The present invention provides a multilayer printed wiring board being composed of a substrate provided with through-holes, and a conductor circuit formed on the substrate through the interposition of an interlaminar insulating resin layer, the through-holes being filled with a filler, wherein the internal surfaces of the through-holes are roughened, and the filler is composed of metal particles, and a thermosetting resin or a thermoplastic resin.

The invention also provides a multilayer printed wiring board being composed of a substrate provided with through-holes, and a conductor circuit formed on the substrate through the interposition of an interlaminar insulating resin layer, the through-holes being filled with a filler, wherein internal surfaces of the through-holes are roughened, and the filler is composed of metal particles and a thermosetting resin or a thermoplastic resin, and an exposed portion of the filler in the through-holes is covered with a through-hole-covering conductor layer.

In addition, the present invention provides a multilayer printed wiring board being composed of a substrate provided with through-holes, and a conductor circuit formed on the substrate through the interposition of an interlaminar insulating resin layer, the through-holes being filled with a filler, wherein internal surfaces of the through-holes are roughened, and the filler is composed of metal particles and a thermosetting resin or a thermoplastic resin, and an exposed portion of the filler in the through-

holes is covered with a through-hole-covering conductor layer, and the through-hole-covering conductor layer is connected to a viahole formed just above the conductor layer.

The present invention provides, in another aspect, a process of producing a multilayer printed wiring board comprising at least the following steps ① to ④:

- ① a step of forming a conductor layer and a through-hole on both surfaces of a substrate by electroless plating, or additionally by electroplating,
- ② a step of forming a roughened layer on the internal surface of the through-hole,
- ③ a step of filling the through-hole provided with the roughened layer on its internal surface with a filler composed of metal particles and a thermosetting resin or a thermoplastic resin, and drying and curing the filler,
- ④ a step of forming an interlaminar insulating resin layer and then forming a conductor circuit by subjecting the substrate to an electroless plating, or additionally to an electroplating.

The invention provides, in yet another aspect, a process of producing a multilayer printed wiring board comprising at least the following steps ① to ⑤:

- ① a step of forming a conductor layer and a through-hole on both surfaces of a substrate by electroless plating, or additionally by electroplating,
- ② a step of forming a roughened layer on the internal surface of the through-hole,
- ③ a step of filling the through-hole with a filler composed of metal particles and a thermosetting resin or a thermoplastic resin, and drying and curing the filler,

④ a step of subjecting an exposed portion of the filler on the through-hole to an electroless plating, or additionally to an electroplating to form a through-hole-covering conductor layer, and

⑤ a step of forming an interlaminar insulating resin layer and then forming a conductor circuit by electroless plating, or additionally by electroplating.

The invention provides, in a yet further aspect, a process of producing a multilayer printed wiring board comprising at least the following steps ① to ⑥:

① a step of forming a conductor layer and a through-hole on both surfaces of a substrate by electroless plating, or additionally by electroplating,

② a step of forming a roughened layer on the internal surface of the through-hole,

③ a step of filling the through-hole provided with the roughened layer on its internal surface with a filler composed of metal particles and a thermosetting resin or a thermoplastic resin, and drying and curing the filler,

④ a step of subjecting an exposed portion of the filler on the through-hole to an electroless plating, or additionally to an electroplating to form a through-hole-covering conductor layer,

⑤ a step of forming an interlaminar insulating resin layer, and

⑥ a step of forming a viahole and a conductor circuit in the interlaminar insulating resin layer located just above the through-hole, and connecting the viahole to the through-hole-covering conductor layer.

In addition and advantageously, the invention provides

a resin composition for filling through-hole of a printed wiring board, which comprises a particulate substance, a resin and an ultrafine inorganic powder.

Brief Description of the Drawings

Fig. 1 is a cross section view illustrating an embodiment of the multilayer printed wiring board according to the present invention.

Fig. 2 (a)-(f) is a diagram illustrating a part of production steps of the multilayer printed wiring board according to the invention.

Fig. 3 (a)-(e) is a diagram illustrating a part of production steps of the multilayer printed wiring board according to the invention.



NEW CLAIMS

1. A multilayer printed wiring board being composed of a substrate provided with through-holes, and a conductor circuit formed on the substrate through the interposition of an interlaminar insulating resin layer, said through-holes being filled with a filler, wherein

an internal surfaces of the through-holes are roughened, and said filler is composed of metal particles and a thermosetting resin or a thermoplastic resin.

2. (cancelled)

3. The multilayer printed wiring board according to Claim 1, wherein the filler is composed of a particulate substance, a resin and an ultrafine inorganic powder.

4. The multilayer printed wiring board according to Claim 3, wherein the filler is a nonconducting composition containing metal particles.

5. The multilayer printed wiring board according to Claim 3, wherein the particulate substance is composed of at least one member selected from metal particles, inorganic particles and resin particles.

6. The multilayer printed wiring board according to Claim 3, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.

7. The multilayer printed wiring board according to Claim 1, wherein the substrate is a multilayer core substrate formed by laminating a conductor layer and a prepreg in alternating order.

8. The multilayer printed wiring board according to Claim 1, wherein the through-holes formed on the substrate





have a pitch interval of equal to or less than 700 μm .

9. The multilayer printed wiring board according to Claim 1, wherein build-up wiring layers formed on both surfaces of the substrate have the same number of layers with each other and the wiring thereof is installed dispersing to the periphery of the substrate.

10. A multilayer printed wiring board being composed of a substrate provided with through-holes, and a conductor circuit formed on the substrate through the interposition of an interlaminar insulating resin layer, said through-holes being filled with a filler, wherein

internal surfaces of the through-holes are roughened, and said filler is composed of metal particles and a thermosetting resin or a thermoplastic resin, and an exposed portion of the filler in the through-holes is covered with a through-hole-covering conductor layer.

11. (canceled)

12. The multilayer printed wiring board according to Claim 10, wherein a roughened layer is formed on the surface of the through-hole-covering conductor layer.

13. (canceled)

14. The multilayer printed wiring board according to Claim 10, wherein the filler is composed of a particulate substance, a resin and an ultrafine inorganic powder.

15. The multilayer printed wiring board according to Claim 14, wherein the filler is a nonconducting composition containing metal particles.

16. The multilayer printed wiring board according to Claim 14, wherein the particulate substance is composed of at least one member selected from metal particles, inorganic





particles and resin particles.

17. The multilayer printed wiring board according to Claim 14, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.

18. The multilayer printed wiring board according to Claim 10, wherein the substrate is a multilayer core substrate formed by laminating a conductor layer and a prepreg in alternating order.

19. The multilayer printed wiring board according to Claim 10, wherein the through-holes formed on the substrate have a pitch interval of equal to or less than 700 μm .

20. The multilayer printed wiring board according to Claim 10, wherein build-up wiring layers formed on both surfaces of the substrate have the same number of layers with each other and the wiring thereof is installed dispersing to the periphery of the substrate.

21. A multilayer printed wiring board being composed of a substrate provided with through-holes, and a conductor circuit formed on the substrate through the interposition of an interlaminar insulating resin layer, said through-holes being filled with a filler, wherein

internal surfaces of the through-holes are roughened, and said filler is composed of metal particles and a thermosetting resin or a thermoplastic resin, and an exposed surface of the filler in the through-holes is covered with a through-hole-covering conductor layer, and a viahole formed just above the conductor layer is connected to the through-hole-covering conductor layer.

22. (canceled)

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23. The multilayer printed wiring board according to Claim 21, wherein a roughened layer is formed on the surface of the through-hole-covering conductor layer.

24. (canceled)

25. The multilayer printed wiring board according to Claim 21, wherein the filler is composed of a particulate substance, a resin and an ultrafine inorganic powder.

26. The multilayer printed wiring board according to Claim 25, wherein the filler is a nonconducting composition containing metal particles.

27. The multilayer printed wiring board according to Claim 25, wherein the particulate substance is composed of at least one member selected from metal particles, inorganic particles and resin particles.

28. The multilayer printed wiring board according to Claim 25, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.

29. The multilayer printed wiring board according to Claim 21, wherein the substrate is a multilayer core substrate formed by laminating a conductor layer and a prepreg in alternating order.

30. The multilayer printed wiring board according to Claim 21, wherein the through-holes formed on the substrate have a pitch interval of equal to or less than 700 μm .

31. The multilayer printed wiring board according to Claim 21, wherein build-up wiring layers formed on both surfaces of the substrate have the same number of layers with each other and the wiring thereof is installed dispersing to the periphery of the substrate.





32. A process of producing a multilayer printed wiring board comprising at least the following steps ① to ④:

① a step of forming a conductor layer and through-holes on both surfaces of a substrate by electroless plating, or additionally electroplating,

② a step of forming a roughened layer on the surfaces of the through-holes,

③ a step of filling the through-holes each having the roughened layer on its internal surface with a filler composed of metal particles, and a thermosetting resin or a thermoplastic resin, and drying and curing the filler,

④ a step of forming an interlaminar insulating resin layer and then forming a conductor circuit by subjecting to an electroless plating, or additionally to an electroplating.

33. The process according to Claim 32, wherein the internal surfaces of the through-holes are roughened by any process selected from an oxidation-reduction treatment, a treatment with an aqueous mixed solution of an organic acid and a copper(II) complex, and a plating with a needle ternary alloy of copper-nickel-phosphorus.

34. (canceled)

35. The process according to Claim 32, wherein the step of filling the through-holes with a filler is conducted by filling the through-holes with a filler composed of a particulate substance, a resin and an ultrafine inorganic powder, and drying and curing the filler.

36. The process according to Claim 35, wherein the step of filling the through-holes with a filler is conducted by filling the through-holes with a filler composed of a





nonconducting composition containing metal particles, and drying and curing the filler.

37. The process according to Claim 35, wherein the particulate substance is composed of at least one member selected from metal particles, inorganic particles and resin particles.

38. The process according to Claim 35, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.

39. A process of producing a multilayer printed wiring board comprising at least the following steps ① to ⑤:

① a step of forming a conductor layer and through-holes on both surfaces of a substrate by electroless plating, or additionally by electroplating,

② a step of forming a roughened layer on the surfaces of the through-holes,

③ a step of filling the through-holes with a filler composed of metal particles, and a thermosetting resin or a thermoplastic resin, and drying and curing the filler,

④ a step of forming a through-hole-covering conductor layer by subjecting an exposed portion of the filler on the through-holes to an electroless plating, or additionally to an electroplating, and

⑤ a step of forming an interlaminar insulating resin layer and then forming a conductor circuit by electroless plating, or additionally by electroplating.

40. (canceled)

41. The process according to Claim 40, wherein the internal surfaces of the through-holes are roughed by any process selected from an oxidation-reduction treatment, a





treatment with an aqueous mixed solution of an organic acid and a copper(II) complex, and a plating treatment with a needle-formed ternary alloy of copper-nickel-phosphorus.

42. (canceled)

43. The process according to Claim 39, wherein the filling step of a filler is conducted by filling the through-holes with a filler composed of a particulate substance, a resin and an ultrafine inorganic powder, and drying and curing the filler.

44. The process according to Claim 43, wherein the filling step of a filler is conducted by filling the through-holes with a filler composed of a nonconducting composition having a specific resistance of equal to or more than $1 \times 10^6 \Omega \cdot \text{cm}^2$ and containing metal particles, and drying and curing the filler.

45. The process according to Claim 43, wherein the particulate substance is at least one member selected from metal particles, inorganic particles and resin particles.

46. The process according to Claim 43, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.

47. The process according to Claim 39, wherein the step of forming the through-hole-covering conductor layer is conducted by applying catalyst nuclei to the surface of the substrate being previously smoothed, subjecting the substrate to an electroless plating, or additionally to an electroplating, then forming an etching resist just above the through-holes and a portion to be a conductor circuit, removing the plating layer in a portion where the etching resist is not formed, and further peeling off the etching





resist on the through-hole-covering conductor layer and the conductor circuit portion.

48. The process according to Claim 39, wherein the step of forming the through-hole-covering conductor layer is conducted by forming a plating resist in a given position on the surface of the substrate being previously smoothed and then subjecting a portion where the resist is not formed to an electroplating to form a through-hole-covering conductor layer and a conductor circuit, and removing the plating resist with the plating film located beneath the resist by etching.

49. The process according to Claim 39, wherein the step of forming a through-hole-covering conductor layer comprises a step of roughening the surface of the through-hole-covering conductor layer by any process selected from an oxidation-reduction treatment, a treatment with an aqueous mixed solution of an organic acid and a copper(II) complex and a plating treatment with a needle-formed ternary alloy of copper-nickel-phosphorus.

50. A process of producing a multilayer printed wiring board comprising at least the following steps ① to ⑥:

① a step of forming a conductor layer and through-holes on both surfaces of a substrate by electroless plating, or additionally by electroplating,

② a step of forming a roughened layer in the internal surfaces of the through-holes,

③ a step of filling the through-holes provided with a roughened layer with a filler composed of metal particles, and a thermosetting resin or a thermoplastic resin, and





drying and curing the filler,

④ a step of forming a through-hole-covering conductor layer on an exposed portion of the filler on the through-holes by electroless plating, or additionally by electroplating,

⑤ a step of forming an interlaminar insulating resin layer, and

⑥ a step of forming a viahole and a conductor circuit in the interlaminar insulating resin layer located just above the through-holes, and connecting the viahole to the through-hole-covering conductor layer.

51. The process according to Claim 50, wherein the internal surfaces of the through-holes are roughened by any process selected from an oxidation-reduction treatment, a treatment with an aqueous mixed solution of an organic acid and a copper(II) complex, or a plating treatment with a needle-formed ternary alloy of copper-nickel-phosphorus.

52. (canceled)

53. The process according to Claim 50, wherein the filling step of a filler is conducted by filling the through-holes with a filler composed of a particulate substance, a resin and an ultrafine inorganic powder, and drying and curing the filler.

54. The process according to Claim 50, wherein the filling step of a filler is conducted by filling the through-holes with a filler composed of a nonconducting composition containing metal particles, and drying and curing the filler.

55. The process according to Claim 53, wherein the particulate substance is at least one member selected from





metal particles, inorganic particles and resin particles.

56. The process according to Claim 53, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.

57. The process according to Claim 50, wherein the step of forming a through-hole-covering conductor layer is conducted by applying catalyst nuclei to the surface of the substrate being previously smoothed, subjecting the substrate to an electroless plating to form a plated layer, or additionally to an electroplating, then forming an etching resist just above the through-holes and a portion where the conductor circuit is formed, removing the plated layer in a portion where the etching resist is not formed, and further peeling off the etching resist on the through-hole-covering conductor layer and the conductor circuit.

58. The process according to Claim 50, wherein the step of forming a through-hole-covering conductor layer is conducted by forming a plating resist in a given position on the surface of the substrate being previously smoothed and then subjecting a portion where the resist is not formed to an electroplating to form a through-hole-covering conductor layer and a conductor circuit, and removing the plating resist and the plated film located beneath the resist through etching.

59. The process according to Claim 50, wherein the step of forming a through-hole-covering conductor layer comprises a step of roughening the surface of the through-hole-covering conductor layer by any process selected from an oxidation-reduction treatment, a treatment with an aqueous mixed solution of an organic acid and a copper(II)





complex or a plating treatment with a needle-formed ternary alloy of copper-nickel-phosphorus.

60. The process according to Claim 50, wherein a viahole is formed just above the through-hole-covering conductor layer through the interposition of an interlaminar insulating resin layer by roughening the interlaminar insulating resin layer provided with an opening for viahole, or applying catalyst nuclei directly to the resin layer without roughening, then subjecting the resin layer to an electroless plating or additionally to an electroplating, and etching the plated layer so as to remain a viahole and a conductor circuit portion.

61. A resin composition for filling through-hole of a printed wiring board being composed of a particulate substance, a resin and an ultrafine inorganic powder.

62. The resin composition according to Claim 61, which is a nonconducting composition containing metal particles.

63. The resin composition according to Claim 61, wherein the particulate substance is composed of at least one member selected from metal particles, inorganic particles and resin particles.

64. The resin composition according to Claim 61, wherein the resin is composed of at least one member selected from a bisphenol type epoxy resin and a novolac type epoxy resin.

65. The resin composition according to Claim 64, wherein the bisphenol type epoxy resin is composed of at least one member selected from bisphenol F type epoxy resins and bisphenol A type epoxy resins.





66. The resin composition according to Claim 64, wherein the novolac type epoxy resin is composed of at least one member selected from phenol novolac type epoxy resins and cresol novolac type epoxy resins.

67. The resin composition according to Claim 64, wherein the composition ratio of the novolac type epoxy resin to the bisphenol type epoxy resin ranges from 1/1 to 1/100 by weight.

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CLAIMS

1. A multilayer printed wiring board being composed of a substrate provided with through-holes, and a conductor circuit formed on the substrate through the interposition of an interlaminar insulating resin layer, said through-holes being filled with a filler, wherein

Internal surfaces of the through-holes are roughened, and said filler is composed of metal particles and a thermosetting resin or a thermoplastic resin.

2. The multilayer printed wiring board according to Claim 1, wherein the filler is composed of a particulate substance, a resin and an ultrafine inorganic powder.

3. The multilayer printed wiring board according to Claim 2, wherein the filler is a nonconducting composition containing metal particles.

4. The multilayer printed wiring board according to Claim 2, wherein the particulate substance is composed of at least one member selected from metal particles, inorganic particles and resin particles.

5. The multilayer printed wiring board according to Claim 2, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.

6. The multilayer printed wiring board according to Claim 1, wherein the substrate is a multilayer core substrate formed by laminating a conductor layer and a prepreg in alternating order.

7. The multilayer printed wiring board according to Claim 1, wherein the through-holes formed on the substrate



have a pitch interval of equal to or less than 700 μm .

8. The multilayer printed wiring board according to Claim 1, wherein build-up wiring layers formed on both surfaces of the substrate have the same number of layers with each other and the wiring thereof is installed dispersing to the periphery of the substrate.

9. A multilayer printed wiring board being composed of a substrate provided with through-holes, and a conductor circuit formed on the substrate through the interposition of an interlaminar insulating resin layer, said through-holes being filled with a filler, wherein

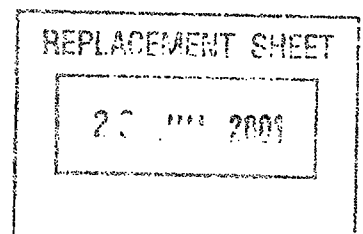
internal surfaces of the through-holes are roughened, and said filler is composed of metal particles and a thermosetting resin or a thermoplastic resin, and an exposed portion of the filler in the through-holes is covered with a through-hole-covering conductor layer.

10. The multilayer printed wiring board according to Claim 9, wherein a roughened layer is formed on the surface of the through-hole-covering conductor layer.

11. The multilayer printed wiring board according to Claim 9, wherein the filler is composed of a particulate substance, a resin and an ultrafine inorganic powder.

12. The multilayer printed wiring board according to Claim 11, wherein the filler is a nonconducting composition containing metal particles.

13. The multilayer printed wiring board according to Claim 11, wherein the particulate substance is composed of at least one member selected from metal particles, inorganic





particles and resin particles.

14. The multilayer printed wiring board according to Claim 11, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.

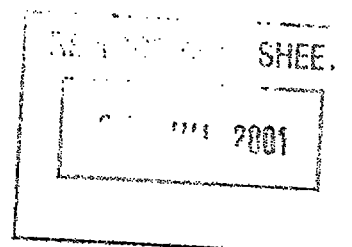
15. The multilayer printed wiring board according to Claim 9, wherein the substrate is a multilayer core substrate formed by laminating a conductor layer and a prepreg in alternating order.

16. The multilayer printed wiring board according to Claim 9, wherein the through-holes formed on the substrate have a pitch interval of equal to or less than 700 μm .

17. The multilayer printed wiring board according to Claim 9, wherein build-up wiring layers formed on both surfaces of the substrate have the same number of layers with each other and the wiring thereof is installed dispersing to the periphery of the substrate.

18. A multilayer printed wiring board being composed of a substrate provided with through-holes, and a conductor circuit formed on the substrate through the interposition of an interlaminar insulating resin layer, said through-holes being filled with a filler, wherein

internal surfaces of the through-holes are roughened, and said filler is composed of metal particles and a thermosetting resin or a thermoplastic resin, and an exposed surface of the filler in the through-holes is covered with a through-hole-covering conductor layer, and a viahole formed just above the conductor layer is connected to the through-hole-covering conductor layer.





19. The multilayer printed wiring board according to Claim 18, wherein a roughened layer is formed on the surface of the through-hole-covering conductor layer.

20. The multilayer printed wiring board according to Claim 18, wherein the filler is composed of a particulate substance, a resin and an ultrafine inorganic powder.

21. The multilayer printed wiring board according to Claim 20, wherein the filler is a nonconducting composition containing metal particles.

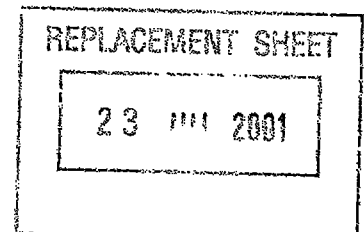
22. The multilayer printed wiring board according to Claim 20, wherein the particulate substance is composed of at least one member selected from metal particles, inorganic particles and resin particles.

23. The multilayer printed wiring board according to Claim 20, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.

24. The multilayer printed wiring board according to Claim 18, wherein the substrate is a multilayer core substrate formed by laminating a conductor layer and a prepreg in alternating order.

25. The multilayer printed wiring board according to Claim 18, wherein the through-holes formed on the substrate have a pitch interval of equal to or less than 700 μm .

26. The multilayer printed wiring board according to Claim 18, wherein build-up wiring layers formed on both surfaces of the substrate have the same number of layers with each other and the wiring thereof is installed dispersing to the periphery of the substrate.





27. A process of producing a multilayer printed wiring board comprising at least the following steps ① to ④:

① a step of forming a conductor layer and through-holes on both surfaces of a substrate by electroless plating, or additionally electroplating,

② a step of forming a roughened layer on the surfaces of the through-holes,

③ a step of filling the through-holes each having the roughened layer on its internal surface with a filler composed of metal particles, and a thermosetting resin or a thermoplastic resin, and drying and curing the filler,

④ a step of forming an interlaminar insulating resin layer and then forming a conductor circuit by subjecting to an electroless plating, or additionally to an electroplating.

28. The process according to Claim 27, wherein the internal surfaces of the through-holes are roughened by any process selected from an oxidation-reduction treatment, a treatment with an aqueous mixed solution of an organic acid and a copper(II) complex, and a plating with a needle ternary alloy of copper-nickel-phosphorus.

29. The process according to Claim 27, wherein the step of filling the through-holes with a filler is conducted by filling the through-holes with a filler composed of a particulate substance, a resin and an ultrafine inorganic powder, and drying and curing the filler.

30. The process according to Claim 29, wherein the step of filling the through-holes with a filler is conducted by filling the through-holes with a filler composed of a



nonconducting composition containing metal particles, and drying and curing the filler.

31. The process according to Claim 29, wherein the particulate substance is composed of at least one member selected from metal particles, inorganic particles and resin particles.

32. The process according to Claim 29, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.

33. A process of producing a multilayer printed wiring board comprising at least the following steps ① to ⑤:

① a step of forming a conductor layer and through-holes on both surfaces of a substrate by electroless plating, or additionally by electroplating,

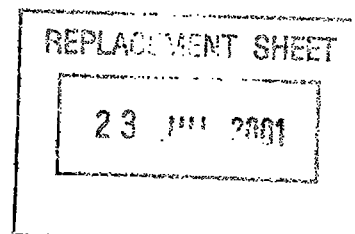
② a step of forming a roughened layer on the surfaces of the through-holes,

③ a step of filling the through-holes with a filler composed of metal particles, and a thermosetting resin or a thermoplastic resin, and drying and curing the filler,

④ a step of forming a through-hole-covering conductor layer by subjecting an exposed portion of the filler on the through-holes to an electroless plating, or additionally to an electroplating, and

⑤ a step of forming an interlaminar insulating resin layer and then forming a conductor circuit by electroless plating, or additionally by electroplating.

34. The process according to Claim 33, wherein the internal surfaces of the through-holes are roughed by any process selected from an oxidation-reduction treatment, a





treatment with an aqueous mixed solution of an organic acid and a copper(II) complex, and a plating treatment with a needle-formed ternary alloy of copper-nickel-phosphorus.

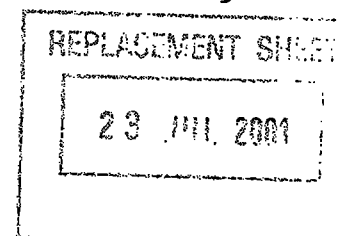
35. The process according to Claim 33, wherein the filling step of a filler is conducted by filling the through-holes with a filler composed of a particulate substance, a resin and an ultrafine inorganic powder, and drying and curing the filler.

36. The process according to Claim 35, wherein the filling step of a filler is conducted by filling the through-holes with a filler composed of a nonconducting composition having a specific resistance of equal to or more than $1 \times 10^6 \Omega\text{-cm}^2$ and containing metal particles, and drying and curing the filler.

37. The process according to Claim 35, wherein the particulate substance is at least one member selected from metal particles, inorganic particles and resin particles.

38. The process according to Claim 35, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.

39. The process according to Claim 33, wherein the step of forming the through-hole-covering conductor layer is conducted by applying catalyst nuclei to the surface of the substrate being previously smoothed, subjecting the substrate to an electroless plating, or additionally to an electroplating, then forming an etching resist just above the through-holes and a portion to be a conductor circuit, removing the plating layer in a portion where the etching resist is not formed, and further peeling off the etching





resist on the through-hole-covering conductor layer and the conductor circuit portion.

40. The process according to Claim 33., wherein the step of forming the through-hole-covering conductor layer is conducted by forming a plating resist in a given position on the surface of the substrate being previously smoothed and then subjecting a portion where the resist is not formed to an electroplating to form a through-hole-covering conductor layer and a conductor circuit, and removing the plating resist with the plating film located beneath the resist by etching.

41. The process according to Claim 33, wherein the step of forming a through-hole-covering conductor layer comprises a step of roughening the surface of the through-hole-covering conductor layer by any process selected from an oxidation-reduction treatment, a treatment with an aqueous mixed solution of an organic acid and a copper(II) complex and a plating treatment with a needle-formed ternary alloy of copper-nickel-phosphorus.

42. A process of producing a multilayer printed wiring board comprising at least the following steps ① to ⑥:

① a step of forming a conductor layer and through-holes on both surfaces of a substrate by electroless plating, or additionally by electroplating,

② a step of forming a roughened layer in the internal surfaces of the through-holes,

③ a step of filling the through-holes provided with a roughened layer with a filler composed of metal particles, and a thermosetting resin or a thermoplastic resin, and



drying and curing the filler,

④ a step of forming a through-hole-covering conductor layer on an exposed portion of the filler on the through-holes by electroless plating, or additionally by electroplating,

⑤ a step of forming an interlaminar insulating resin layer, and

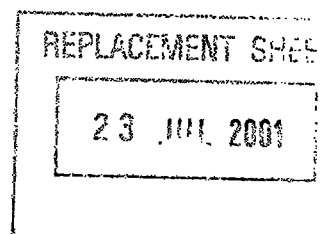
⑥ a step of forming a viahole and a conductor circuit in the interlaminar insulating resin layer located just above the through-holes, and connecting the viahole to the through-hole-covering conductor layer.

43. The process according to Claim 42, wherein the internal surfaces of the through-holes are roughened by any process selected from an oxidation-reduction treatment, a treatment with an aqueous mixed solution of an organic acid and a copper(II) complex, or a plating treatment with a needle-formed ternary alloy of copper-nickel-phosphorus.

44. The process according to Claim 42, wherein the filling step of a filler is conducted by filling the through-holes with a filler composed of a particulate substance, a resin and an ultrafine inorganic powder, and drying and curing the filler.

45. The process according to Claim 42, wherein the filling step of a filler is conducted by filling the through-holes with a filler composed of a nonconducting composition containing metal particles, and drying and curing the filler.

46. The process according to Claim 44, wherein the particulate substance is at least one member selected from





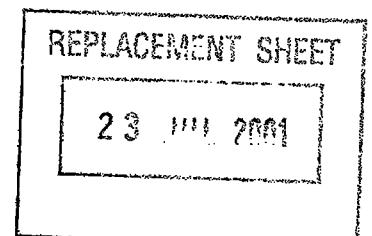
metal particles, inorganic particles and resin particles.

47. The process according to Claim 44, wherein the resin is composed of at least one member selected from bisphenol type epoxy resins and novolac type epoxy resins.

48. The process according to Claim 42, wherein the step of forming a through-hole-covering conductor layer is conducted by applying catalyst nuclei to the surface of the substrate being previously smoothed, subjecting the substrate to an electroless plating to form a plated layer, or additionally to an electroplating, then forming an etching resist just above the through-holes and a portion where the conductor circuit is formed, removing the plated layer in a portion where the etching resist is not formed, and further peeling off the etching resist on the through-hole-covering conductor layer and the conductor circuit.

49. The process according to Claim 42, wherein the step of forming a through-hole-covering conductor layer is conducted by forming a plating resist in a given position on the surface of the substrate being previously smoothed and then subjecting a portion where the resist is not formed to an electroplating to form a through-hole-covering conductor layer and a conductor circuit, and removing the plating resist and the plated film located beneath the resist through etching.

50. The process according to Claim 42, wherein the step of forming a through-hole-covering conductor layer comprises a step of roughening the surface of the through-hole-covering conductor layer by any process selected from an oxidation-reduction treatment, a treatment with an aqueous mixed solution of an organic acid and a copper(II)





complex or a plating treatment with a needle-formed ternary alloy of copper-nickel-phosphorus.

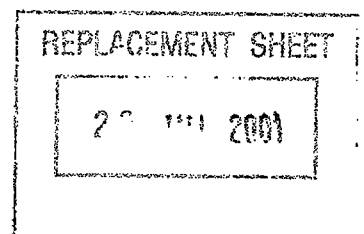
51. The process according to Claim 42, wherein a viahole is formed just above the through-hole-covering conductor layer through the interposition of an interlaminar insulating resin layer by roughening the interlaminar insulating resin layer provided with an opening for viahole, or applying catalyst nuclei directly to the resin layer without roughening, then subjecting the resin layer to an electroless plating or additionally to an electroplating, and etching the plated layer so as to remain a viahole and a conductor circuit portion.

52. A resin composition for filling through-hole of a printed wiring board being composed of a particulate substance, a resin and an ultrafine inorganic powder said composition being a nonconducting composition containing metal particles.

53. The resin composition according to Claim 52, wherein the particulate substance is composed of at least one member selected from metal particles, inorganic particles and resin particles.

54. The resin composition according to Claim 52, wherein the resin is composed of at least one member selected from a bisphenol type epoxy resin and a novolac type epoxy resin.

55. The resin composition according to Claim 54 wherein the bisphenol type epoxy resin is composed of at least one member selected from bisphenol F type epoxy resins and bisphenol A type epoxy resins.





56. The resin composition according to Claim 54 , wherein the novolac type epoxy resin is composed of at least one member selected from phenol novolac type epoxy resins and cresol novolac type epoxy resins.

57. The resin composition according to Claim 54 , wherein the composition ratio of the novolac type epoxy resin to the bisphenol type epoxy resin ranges from 1/1 to 1/100 by weight.

